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EXPRESS CERTIFICATE OF MAILING

Express Mail Certificate No. EV284867597US

I hereby certify that the attached correspondence comprising: 1). Supplemental Declaration of Eddie E. Scott of Prior Invention by Anthony J. Ruggiero to Overcome Cited Patent under 37 CFR §1.131 (17 pages) w/attachments (48 pages) is being deposited with the United States Postal Service "Express Mail Post Office to addressee" in an envelope addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, Alexandria, VA 22313-1450, on **June 24, 2004**.

Kathy Raymond

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Anthony J. Ruggiero	Docket No. :		IL-9928
Serial No.	:	09/877,961	Art Unit :		1753
Filed	:	06/08/2001	Examiner :	:	Kaj K. Olsen
For	:	CHEMICAL MICRO-SENSOR			

SUPPLEMENTAL DECLARATION UNDER 37 CFR §1.131

(Portions <u>Underlined</u> are Supplemental)

Declaration of Eddie E. Scott of

Prior Invention by Anthony J. Ruggiero to Overcome Cited Patent

Commissioner of Patents and Trademarks Alexandria, VA 22313-1450

Dear Sir:

- I, Eddie E. Scott, hereby declare that:
- (1) I am the attorney representing the inventor, Anthony J. Ruggiero, named in the subject application and the owner of the application, the University of California and I am the Declarant in the DECLARATION UNDER 37 CFR §1.131 filed December 22, 2003 in the subject application;

- (2) I am a citizen of the United States and a resident of Danville, California:
- (3) My education includes: Bachelor of Science Degree, University of Wyoming; Master of Science Degree, University of Texas at Dallas; Juris Doctor Degree, University of Wyoming; Patent Office Academy, Basic and Advanced, United States Patent and Trademark Office, Washington, D.C.;
- (4) I am an active member of the State Bar of California, an inactive member of the State Bars of Texas and Wyoming, and I am registered to practice before the United States Patent and Trademark Office;
- (5) I am employed by the University of California, at the Lawrence Livermore National Laboratory, Livermore, California, as Assistant Laboratory Counsel, having been employed by the University of California, at the Lawrence Livermore National Laboratory from May 1, 1999 to the present, and I am empowered to act on behalf of The Regents of the University of California, the owner of the subject application. I was employed by the University of California, at the Lawrence Livermore National Laboratory, Livermore California, in the Industrial Partnership and Commercialization Office from May 1, 1999 until June 1, 2000, at which time I transferred to the Office of Laboratory Counsel where I have worked continuously from June 1, 2004 to the present;
- (6) The claims in the subject application were rejected over the primary reference, U.S. Patent No. 6,381,025 (Bornhop et al. Reference) and another secondary reference; the primary Bornhop et al. Reference issued April 30, 2002 from an application filed March 6, 2000 and was based upon a provisional application filed on August 19, 1999; therefore, August 19, 1999 is the earliest effective date of the Bornhop et al. Reference;
- (7) I have obtained copies of certain documents (The Documents) maintained in the ordinary course of business of the University of California, the

Lawrence Livermore National Laboratory, and the United States Department of Energy (DOE) and I am one of the custodians of The Documents; copies of The Documents are attached hereto as Attachments A-AC, the Attachments A-AC have certain dates blacked out,

attached are new copies of Attachments A-AC and the dates have not been blacked out on the new copies of Attachments A-AC;

(8) The Documents included as exhibits to my declaration have the dates blacked out as provided for in MPEP § 715.07, however the dates appear in the new copies of the exhibits Attachments A-AC;

MPEP § 715.07 Facts and Documentary Evidence - ESTABLISHMENT OF DATES, provides, "If the dates of the exhibits have been removed or blocked off, the matter of dates can be taken care of in the body of the oath or declaration. When alleging that conception or a reduction to practice occurred prior to the effective date of the reference, the dates in the oath or declaration may be the actual dates or, if the applicant or patent owner does not desire to disclose his or her actual dates, he or she may merely allege that the acts referred to occurred prior to a specified date;"

I believe the procedure of blacking out the dates is desirable to protect the Applicant's rights because the actual dates may become important in later proceedings and it would be detrimental for me to disclose exactly how early are Tony J. Ruggiero's dates;

(9) The Documents show that The Inventor, Anthony J. Ruggiero, made the invention described and claimed in the subject patent application (hereinafter "The Invention") in this country prior to August 19, 1999; that Anthony J. Ruggiero conceived The Invention in this country on 7/10/93 which is prior to August 19, 1999; that Anthony J. Ruggiero made written descriptions of The Invention in this country prior to August 19, 1999; that Anthony J. Ruggiero

disclosed The Invention to others in this country prior to August 19, 1999; that Anthony J. Ruggiero reduced The Invention to practice in this country prior to August 19, 1999; and that Anthony J. Ruggiero continuously worked on testing, developing, and patenting The Invention during the period from the time when he made the first written description of The Invention and disclosed The Invention to others, and specifically worked on testing, developing, and patenting The Invention from August 19, 1999, the earliest effective date of the Bornhop et al Reference until 06/08/2001when the subject application was filed (hereinafter "The Time Period");

- (10) The Inventor, Anthony J. Ruggiero, completed a "RECORD OF INVENTION," ATTACHMENT A is photostatic copy of the "RECORD OF INVENTION," the entries for the dates on ATTACHMENT A have been blacked out; however, the dates appear in the new copy of ATTACHMENT A and the dates are prior to August 19, 1999, the stamped date in the upper left corner of page 1 shows that ATTCHMENT A was RECEIVED MAR 23, 1995 LLNL PATENT GROUP, the signatures and dates on page 3 by the inventor and witness are March 23, 1996;
- (ATTACHMENT A) includes includes three attachments and the entries for the dates on the three attachments have been blacked out; however, the dates appear in the new copy of ATTACHMENT A's three attachments, and the dates are prior to August 19, 1999, the date on page 1 of the attachment titled "Advanced Concepts Program" is June 27, 1995 and the dates on the attachment titled "INTEGRATED OPTIC CAPILLARY ELECTROPHORESIS MICOSENSOR" ARE BETWEEN 1996 AND 1999;
- (12) The photostatic copy of the "RECORD OF INVENTION"

 ATTACHMENT A, in the Conception Date Place, Section X, contains an entry for

the "Conception Date," the entry has been blacked out; however, the date appears in the new copy of ATTACHMENT A and is 7/10/93 and therefore the entry is prior to August 19, 1999 and the "Conception Place" entry LLNL is in this country (USA);

- (13) The photostatic copy of the "RECORD OF INVENTION"

 (ATTACHMENT A) also includes sections showing that Anthony J. Ruggiero made The Invention in this country prior to August 19, 1999, that Anthony J. Ruggiero made written descriptions of The Invention in this country prior to August 19, 1999, that Anthony J. Ruggiero disclosed The Invention to others in this country prior to August 19, 1999, that Anthony J. Ruggiero reduced The Invention to practice in this country prior to August 19, 1999, and that testing, developing, and patenting of The Invention was continuously worked on during The Time Period;
- Invention was reduced to practice in this country prior to August 19, 1999 and The "RECORD OF INVENTION" (ATTACHMENT A) includes section XI. Reduction to Practice with entries for Date first model completed and Date of operation and testing, the entries have been blacked out; however, the dates appear in the new copy of ATTACHMENT A as Date first model completed: July 1994 and Date of operation and testing July 1994 therefore the entries are prior to August 19, 1999, the results of testing of The Invention were prior to August 19, 1999 and The Invention was to reduced to practice in this country prior to August 19, 1999; the dates on the photostatic copies have been blacked out, however, all the dates appear in the new copy of ATTACHMENT A and the dates are prior to August 19, 1999;

ATTACHMENT A consists of three (3) parts, the first part is a competed Record of Invention (ROI) form and the second and third parts are documents

attached to the ROI, the directions for the inventor to use in completing the ROI are the following:

Forms:

Submit Record Of Invention (ROI) Form if applicable.

««Download PDF version of the ROI form (E-Form LL6419)

- Contact the LLNL Intellectual Property Law Group at 2-7272 with questions
- <u>Different file formats of the form can be obtained from the LLNL</u>

 <u>Electronics Forms Library at http://www-r.llnl.gov/eforms/eforms_lib.html#6400</u>

 Title:

Be brief - one line - succinct and to the point. The title should provide just enough information to identify the Invention without giving details so we can use the title freely.

Inventors:

Include all those and only those whose contributions are necessary. This may include inventors from outside LLNL (they are listed separately on the form). If the Invention is licensed, all inventors share equally in royalty distribution unless all agree in writing to a different distribution.

Abstract of the Invention:

Need one or two paragraphs; keep to the point.

Uses of the Invention:

- Government Use permits assessment of the need to establish defenses
- Commercial Use needed to help gauge and define markets, to formulate licensing strategy, and to establish Fields of Use (all this information is important for licensing)

Documents Describing Prior Art:

Disclosure publications by others that relate to the inventions:

- To cite to the US Patent Office
- To assess the scope of the invention and help in claim drafting

Background of the Invention: The write-up should discuss:

- The State of the Art
- Problems that the invention solves
- Improvements over existing technologies
- Surprising results of discoveries
- <u>Dramatic changes</u>

Detailed Description of the Invention:

- Keep it brief one to a few pages
- Provide drawings or sketches to help understand the Invention

- Append materials already written (papers, journal articles, etc.)
- Be specific it helps us understand and formulate searches
- Indicate the breadth of the Invention

Inventor Information:

- Patent applications are filed in the name of the inventor(s)
- Assignees and the Patent Office need to be able to communicate with the inventors
- Patent applications are not public; issued patents cite the inventor's residence location

Funding Source Information:

- Provide the account number of the work that led to the invention
- <u>Account numbers determine which Directorates receive shares of</u> revenues
- B&R codes tell DOE if and how rights are transferred to UC
- <u>CRADA and WFO information is used to determine the rights of private sponsors</u>

Conception of the Invention:

- Conception is when the Invention has been mentally formulated
- Need date when this took place
- Documentation is when conception was first recorded
- Must be corroborated by witnesses who understand the Invention and can testify, if necessary

Reduction to Practice:

- Date when Invention was first built, operated, and tested
- Need witnesses to corroborate
- Good idea to keep notebooks
- May need evidence to show we invented before
 - Another who claims to have made the same Invention, or
- A publication describing the invention before our application was filed (<1 year)

Signatures:

0

Inventor(s) sign and date

Witness also needs to sign - Signature witness does not need to understand the Invention, only

ADC Review

Authorized Derivative Classifiers (ADCs) are required to review the document to satisfy Classification Office requirements.

(15) During The Time Period the Industrial Partnership and Commercialization Office (IPAC) of the Lawrence Livermore National Laboratory held monthly Invention Review Meetings and The Invention was reviewed at the Invention Review Meetings during The Time Period; IPAC continuously reviews inventions and prioritizes inventions for patent application filing; The Invention was reviewed and prioritized by IPAC during The Time Period; photostatic copies of a database entries showing that The Invention was reviewed by IPAC during The Time Period are attached as Attachments B, C, and D;

the dates on the photostatic copy of ATTACHMENT B have been blacked out, however, all the dates appear in the new copy of ATTACHMENT B as "High 20 Date: June 1999," "Selected by IPAC for Top 20 (Weis/Dunipace)
6/23/99," and "Added to Top 20 List July 7, 1999";

the dates on the photostatic copy of ATTACHMENT C have been blacked out, however, all the dates appear in the new copy of ATTACHMENT C and specifically the following dates appear in the new copy of ATTACHMENT C: "Rights Requested 5/25/1999," "Rights Granted 9/7/2000," and "Priority List 7/7/99";

the dates on the photostatic copy of ATTACHMENT D have been blacked out, however, all the dates appear in the new copy of ATTACHMENT D and specifically the following dates appear in the new copy of ATTACHMENT D:

"Disclosure Submitted 4/9/1996";

(16) During The Time Period the Office of Laboratory Counsel (OLC) of the Lawrence Livermore National Laboratory, held monthly Invention Review Meetings and The Invention was reviewed at the Meetings during The Time Period; the Office of Laboratory Counsel (OLC) also held monthly meetings with the Industrial Partnership and Commercialization Office (IPAC) during The

Time Period and The Invention was reviewed at the Meetings; OLC prepares patent applications for filing according to a priority list; the parent application of the subject application was prepared by OLC covering The Invention according to the priority list; photostatic copies of a database entries showing that The Invention was reviewed and a patent application filed by OLC during The Time Period are attached as Attachments E, F, G, H, I, J, and K;

the dates on the photostatic copy of ATTACHMENT E have been blacked out, however, all the dates appear in the new copy of ATTACHMENT E and specifically the following dates appear in the new copy of ATTACHMENT E:

"Attorney Scott - Date Attorney Assigned 6/1/2000," "Disclosure Submitted
4/9/1996," "Application Authorized 5/25/1999," "Rights Requested 5/25/1999"
and "Rights Granted 9/7/2000";

the dates on the photostatic copy of ATTACHMENT F have been blacked out, however, all the dates appear in the new copy of ATTACHMENT F and specifically the following dates appear in the new copy of ATTACHMENT F:

"Application Authorized 5/25/1999," "Application Mailed 6/8/2001," "Disclosure Submitted 4/9/1996," "Rights Granted Date 9/7/2000"; "High 20 Nominated Candidate 6/23/99," and "High 20's List 7/7/1999";

the dates on the photostatic copy of ATTACHMENT G have been blacked out, however, all the dates appear in the new copy of ATTACHMENT G and specifically the following dates appear in the new copy of ATTACHMENT G: "Disclosure Submitted 4/9/1996," "Application Authorized 5/25/1999," and "High 20's List 7/7/1999";

the dates on the photostatic copy of ATTACHMENT H have been blacked out, however, all the dates appear in the new copy of ATTACHMENT H and specifically the following dates appear in the new copy of ATTACHMENT H:

"Disclosure Submitted 4/9/1996" and "Application Authorized 5/25/1999";

the dates on the photostatic copy of ATTACHMENT I have been blacked out, however, all the dates appear in the new copy of ATTACHMENT I and specifically the following dates appear in the new copy of ATTACHMENT I:

"Patent Priority List 7/7/1999" and "Authorized 5/25/1999";

the dates on the photostatic copy of ATTACHMENT J have been blacked out, however, all the dates appear in the new copy of ATTACHMENT J and specifically the following dates appear in the new copy of ATTACHMENT J:

"Disclosure Date 4/9/1996" and "Patent Filing Date 6/8/2001";

the dates on the photostatic copy of ATTACHMENT K have been blacked out, however, all the dates appear in the new copy of ATTACHMENT K and specifically the following dates appear in the new copy of ATTACHMENT K:

"Added to List 7/7/1999";

(17) During The Time Period The Invention was continuously worked on; photostatic copies of documents maintained in the ordinary course of business of the University of California, the Lawrence Livermore National Laboratory, and the United States Department of Energy (DOE) showing that The Invention was continuously worked on during The Time Period are attached as Attachments L, M, N, O, P, Q, R, S, T, U, V, W, X, Y, Z, AA, AB, and AC;

the dates on the photostatic copies of ATTACHMENTS L, M, N, O, P, Q, R, S, T, U, V, W, X, Y, Z, AA, AB, and AC have been blacked out, however, all the dates appear in the new copies of ATTACHMENTS L, M, N, O, P, Q, R, S, T, U, V, W, X, Y, Z, AA, AB, and AC and specifically the dates of the documents are as shown in the following table:

Attachment	DATE
<u>L</u>	April 10, 1996
<u>M</u>	Apr 19, 1996
<u>N</u>	<u>July 23, 1996</u>

<u>O</u>	<u>July 23, 1996</u>
<u>P</u>	<u>July 23, 1996</u>
Q	Apr 19, 1996
<u>R</u>	May 25, 1999
<u>S</u>	May 25, 1999
<u>T</u>	<u>Jul 15, 1999</u>
<u>U</u>	Sep 07, 2000
<u>V</u>	May 25, 1999
<u>W</u>	4/10/01
<u>X</u>	<u>5/22/01</u>
<u>Y</u>	<u>Jun 04, 2001</u>
<u>Z</u>	April 11, 2000
<u>AA</u>	<u>June 4, 2001</u>
<u>AB</u>	<u>June 8, 2001</u>
AC	June 8, 2001

I met with the inventor, Anthony J. Ruggiero, during the preparation of the patent application and sent drafts of the patent application to the inventor, Anthony J. Ruggiero, for his review and comment;

Because of the complexity of the invention I ask for and received assistance from another patent attorney, Ann Lee, and another scientist, Gary Johnson; I met with Ann Lee and Gary Johnson and discussed drafts of the patent application and sent drafts of the patent application to Ann Lee and Gary Johnson for their input; I met with a patent draftsman, Don Lambert, and discussed the preparation of the patent drawings and provided a copy of a draft of the patent application to the patent draftsman, Don Lambert;

the Office of Laboratory Counsel (OLC) prepared patent applications for filing according to a priority list during The Time Period, the parent application

of the subject application was prepared by OLC covering The Invention
according to the priority list during The Time Period, a photostatic copy of the
OLC "Monthly Report Worksheet – August 1999" is attached as ATTACHMENT
S-1, showing that the file for the subject application "9928," was one of 174 Patent
Applications requested by IPAC and that the subject invention "9928" was
assigned to the Manager of the Patent Group – John Wooldridge,

on page 3 of ATTACHMENT S-1, the subject invention "9928" is listed in numerical order as one of the 174 Patent Applications requested by IPAC,

on page 17 of ATTACHMENT S-1, the subject invention "9928" is listed in as one of the inventions assigned to the Manager of the Patent Group – John Wooldridge,

a photostatic copy of page 19 of the OLC "Monthly Report Worksheet –

October 1, 1999 to October 31, 1999" is attached as ATTACHMENT S-3, showing

that the subject invention "9928" remained assigned to the Manager of the Patent

Group – John Wooldridge,

a photostatic copy of page 20 of the OLC "Monthly Report Worksheet –

November 1999" is attached as ATTACHMENT S-4, showing that the subject
invention "9928" remained assigned to the Manager of the Patent Group – John
Wooldridge,

a photostatic copy of page 21 of the OLC "Monthly Report Worksheet –

December 1999" is attached as ATTACHMENT S-5, showing that the subject invention "9928" remained assigned to the Manager of the Patent Group – John Wooldridge,

a photostatic copy of page 13 of the OLC "Monthly Report Worksheet –

January 2000" is attached as ATTACHMENT S-6, showing that the subject

invention "9928" remained assigned to the Manager of the Patent Group – John

Wooldridge,

a photostatic copy of page 15 of the OLC "Monthly Report Worksheet – February 2000" is attached as ATTACHMENT S-7, showing that the subject invention "9928" remained assigned to the Manager of the Patent Group – John Wooldridge,

a photostatic copy of page 13 of the OLC "Monthly Report Worksheet –

March 2000" is attached as ATTACHMENT S-8, showing that the subject

invention "9928" remained assigned to the Manager of the Patent Group – John

Wooldridge,

a photostatic copy of page 12 of the OLC "Monthly Report Worksheet –

April 2000" is attached as ATTACHMENT S-9, showing that the subject
invention "9928" remained assigned to the Manager of the Patent Group – John
Wooldridge,

the OLC experience significant Patent Attorney staff problems during the years 1999 and 2000 and as a result of the OLC Patent Attorney staff problems the subject invention "9928" remained part of a back log of inventions wherein patent applications had been requested by IPAC but applications had not been started,

in 1999 the OLC Patent Attorney staff consisted of four Patent Attorneys

(John Wooldridge, Daryl Grzybicki, Lloyd Dakin, and Alan Thompson), one

Patent Attorney (Bud Carhahan) worked as a contract attorney but was not part
of the Patent Attorney staff,

during 1999 one of the four patent attorneys, (Lloyd Dakin) resigned, (Resigned December 2, 1999),

during 1999 one of the four Patent Attorneys, Daryl Grzybicki, died (Died December 15, 1999),

on March 1, 2000 the manager of the OLC Patent Attorney Staff, John

Wooldridge, resigned, which left only one staff Patent Attorney (Alan Thompson),

I worked in the Industrial Partnership and Commercialization Office

(IPAC) from May 1, 1999 until June 1, 2000, at which time I transferred to the

Office of Laboratory Counsel (OLC) which increased the Patent Attorney Staff to
two, shortly thereafter Ann Lee joined the Patent Attorney staff,

the first six inventions that were assigned to me to prepare patent applications included the subject invention "9928,"

a photostatic copy of page 10 of the OLC "Monthly Report Worksheet –
For the Period May 1, 2000 to May 31, 2000" is attached as ATTACHMENT S-10,
showing that the subject invention "9928" was assigned to me during the period
May 1, 2000 to May 31, 2000, the May 2000 Monthly Report ATTACHMENT S-10
shows that the subject invention "9928" was assigned to me when I started June
1, 2000,

photostatic copies of my calendars from June 2000 through June 2001 are attached as ATTACHMENT S-11, the subject invention "9928" was an invention made by a scientist at the Nonproliferation, Arms Control, and International Security (NAI) Directorate, Dr. Anthony J. Ruggiero, on Tuesday June 6, 2000 I attended the IPAC Patent Reviews and I attended the NAI Patent Review at 10:00AM, on Wednesday June 7, 2000 at 1:30 PM I met with the inventor of the subject invention "9928" to start the preparation of a patent application covering the subject invention "9928, and on June 27, 2000 at 10:30 AM I attended the Patent Priority Meeting,"

the mission of the Nonproliferation, Arms Control, and International

Security (NAI) Directorate is to provide technology, analysis, and expertise to aid
the United States government in preventing the spread or use of weapons of
mass destruction, the inventor of the subject invention "9928," Dr. Anthony J.

Ruggiero, is an important and very busy scientist at NAI, and while he was cooperative and helpful in explaining the invention and preparing drafts of the patent application, it was difficult for me as newly within the Office of Laboratory Counsel staff to prepare the final patent application and I prepared many drafts of the patent application and consulted with numerous others in preparing the patent application,

on Tuesday July 11, 2000 I attended the IPAC Patent Reviews and I

attended the NAI Patent Review at 9:15AM and on July 25, 2000 at 10:30 AM I

attended the Patent Priority Meeting,"

on August 22, 2000 at 10:30 AM I attended the Patent Priority Meeting and at 3:00 PM I met with Annemarie Meike, the NAI representative from IPAC regarding preparing the patent application for the subject invention 9928,

on September 26, 2000 at 10:30 AM I attended the Patent Priority Meeting, on Wednesday October 4, 2000 at 2:30 PM I met with the inventor of the subject invention "9928" Dr. Anthony J. Ruggiero, to review a draft of the patent application and to obtain help with the preparation of the patent application covering the subject invention "9928, and on October 24, 2000 at 10:30 AM I attended the Patent Priority Meeting,"

on Friday November 17, 2000 at 1:30 PM I met with the inventor of the subject invention "9928" Dr. Anthony J. Ruggiero, to review another draft of the patent application and to obtain additional help with the preparation of the patent application covering the subject invention "9928, and on November 28, 2000 at 10:30 AM I attended the Patent Priority Meeting,"

on Thursday January 25, 2001 at 2:00 PM I attended the Patent Priority Meeting,

on Thursday February 27, 2001 at 10:30 AM I attended the Patent Priority Meeting,

on Thursday March 27, 2001 at 10:30 AM I attended the Patent Priority Meeting,

on Wednesday April 11, 2001 at 2:00 PM I met with the inventor of the subject invention "9928" Dr. Anthony J. Ruggiero and another scientist Gary Johnson, to review another draft of the patent application and to obtain additional help with the preparation of the patent application covering the subject invention "9928, and on April 24, 2001 at 10:30 AM I attended the Patent Priority Meeting,"

on Thursday May 29, 2001 at 10:30 AM I attended the Patent Priority Meeting,

on Friday June 8, 2001 I filed the subject patent application,

during the period from June 1, 2000 until June 8, 2001 that the subject invention "9928" was assigned to me to prepare and file a patent application, I continuously worked on preparing drafts of the patent application, meeting with the inventor and other individuals to learn more about the invention and to revise drafts of the patent application, among the other individuals were patent attorney, Ann Lee and scientist, Gary Johnson,

- (18) I do not know and do not believe that the invention has been in public use or on sale in this country, or patented or described in a printed publication in this or any foreign country for more than one year prior to the application, and I believe the inventor has never abandoned his invention;
- (19) I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States

Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

(Signature)

Declarant: Eddie E. Scott

Dated:

Livermore, California

Disclosur	es Sent to DOE	•
10552 ((Knapp) Sphere Implosion Initiation Device
10560	Engineering	(Mariella) Building Airspace Protection System
10567	Engineering	(Funkhouser) Enhanced Safety Load-bearing
		Kinematic Mount Design
10570	Engineering	(Williams) Ball Mill Axial Discharge Apparatus
10571	Lasers	(Beach) Tapered Laser Rods as a Means of
		Minimizing the Path Length of Trapped Barrel
	•	Mode Rays
10574	Engineering	(McNab) In Situ Treatment of Contaminated
		Groundwater by Catalytic Reductive
		Dehalogenation Facilitated by Water Electrolysis
		with an Electrode Array
10575	C&MS	(Tillotson) Metal Oxide Energetic Material
		Synthesis using Sol-Gel Chemistry
10576	Engineering	(Krulevitch) Handheld Personal Computer Capable
	0. 0	of Real Time Data Entry
10577	Engineering	(Stever) High Speed Radar (HSR): An Apparatus
		for Transmitting and Receiving Ultra-wideband
		Electromagnetic Pulses used for High-speed
		Interrogation of Targets Moving at a High Velocity
	:	Relative to the Radar
10578	Other	(Lowe) GDP-L-Fucose: β-D-Galactoside 2-α-L-
	•	Fucosyltransferases, DNA Sequences Encoding the
		Same, Method for Producing the Same and a
	•	Method of Genotyping a Person
10579	C&MS	(Fox) Dendritic Methodology Applied to the
		Prediction, Design and Synthesis of Low Density
		Materials
10580	Engineering	(Krulevitch) Microfabricated Instrument for Tissue
	0	Biopsy and Genetic Analysis
10581	Engineering	(Krulevitch) Method for Producing Microchannels
		having Circular Cross-sections in Glass
10582	Engineering	(Benett) Convectively Driven PCR Thermal-
	0	Cycling
10583	Other	(Gibbons) Thin Film Read head Structure with
		Improved Bias Magnet-to-Magnetoresistive
	• .	Element Interface and Method of Fabrication
	•	Demon interface and interfiod of Padrication

Disclosures Pending Submittal:

	_	
10411-CR	Lasers	(Hale) Projection Optics Box
10460	C&MS	(Stevens) Low Friction Materials for Use at
10469	OTHER??	Cryogenic Temperatures (Arsdall) CORBA-Based Simulator Integrated Computer

Applications	Authorized by	v IP&C
8480	Lasers	(Solarz) A Microchannel Cooled Edge Cladding to Establish an Adiabatic Boundary Condition in a
8936	Lasers	Slab Laser
9396		(Manes) Lensless Projection Lithography
9449	C&MS '	(Hrubesh) Lightweight Gradient-Index Lenses
9449	EE	(Thomas) High Voltage Clamp for Application to Time-of-Flight, Mass Spectrometer
9466	EE	(Yee) Modulated Doping
9522	Lasers	(Ebbers) Compact Compensated Q-Switch
9530	Physics	(Bonde) Etch-Plate-Sputter-Etch Technique to Fabricate Gated Microfilaments
9598	ME	(Thelin) Water Soluble Crystal Polishing Using Aluminum Oxide and Formamide GR
9626	C&MS	(Reynolds) Process for Removing Metals from Crude Oils
9639	Physics	(Kare) High-Radiance Non-Coherent Light Source
9640	Lasers	(McEwan) Precision Wideband Radar Rangefinder
9682	Lasers	(McEwan) Magneto-Radar Hidden Metal Detector
9725	Lasers	(McEwan) Headset Mounted Microradar Throat Microphone
9726	Lasers	(McEwan) Microradar Voice Alteration Device
9728	Lasers	(McEwan) Rangefinder with FCC Complaint
9751	C&MS	Spectrum (Hsu) Recovery of Silver from Waste Silver Chloride
9753	C&MS	(Zundelevich) Oxidation of Nitrous to Nitric Acid in Self-Aerated Gas-Liquid Contractors
9769	ME	(Beckwith) An Electronic Means for Cancellation
9773	T	of Periodic Error in Heterodyne Interferometry
9800	Lasers EE	(Vann) Plasma Electrode Semiconductor Laser
	EE ·	(Portnoff) Radar Assisted Time-Scale Modification of Speech
9816	EE	(Thomas) Collimator Application for Resolution Improvement of Microchannel Plate Image
9817	EE	(Baker) Solid State Infrared Camera
9819	PE (Other)	(Morrow) Sonar Pipe Assessment Probe
9832	Lasers	(Toeppen) Laser Rangefinder Coaxial Optics
9840	EE	(Sampayan) Large Area Diamond Photocathode
9841	Lasers	System (McFwan) Improved Illera Widehard Bessiese
9858	Physics	(McEwan) Improved-Ultra-Wideband Receiver
7000	Titysics	(Erskine) Achromatic Superimposing Delay Designs
		·

9862	Physics	(Bonde) Patterning Flat Panel Display Aerogel
9863	Weapons	Spacers by Physical Abrasion (Seppala) A Molded Acrylic Nested Lens for
9865	Lasers	Efficient Illumination and Light Collection (McEwan) High Strobe Rejection Ultra-Wideband Receiver
9866	EE	(Portnoff) Efficient Method for In-Situ Matrix Transpose
9870	Lasers	(Skidmore) Low-Cost Monolithic Laser Diode Array
9875	C&MS	(Cooper) Large-Area Decontamination Using
9893	C&MS	Peroxydisulfate with UV and Metal-Ion Catalysis (Hrubesh) Ultra-Lightweight Diaphragms from Laminated Aerogel
9908	Lasers	(Trebes) X-Ray Source for Use on an Intravascular Catheter
9909	Lasers	(Meyers) Electron Beam Current Monitor Using Oxidized or Nitrided Silicon
9910	EE.	(Sampayan) High Power Discharge Closing Switch
9916	Env. Sci.	(Yow) Method for Increasing Soil Permeability
		and Heating Soil in situ for Thermally Enhanced
		Site Remediation
9917	Lasers	
,,,,,,	Luscis	(Trebes) Acoustic Detection of Vascular Defects within the Head
9918	Lasers	
<i>)</i>	Lasers	(Trebes) Intravascular X-Ray Catheter Radiation
9925	Dhysics	Monitor
9923	Physics	(Bonde) Patterning Flat Panel Display Porous
0000		Material Spacers by Physical Abrasion
9928	NAI	(Ruggiero) Integrated Optical Capillary
0004		Electrophoresis Chemical Microsensor
9931	Other	(Hunter) Gaseous Fuel Supply for Lighter than
		Air Vehicles
9932	ME	(Barksdale) Zero Input End Spoiled Microchannel
		Plate
9943	ME	(Biltoft) Micro Wheatstone Bridge Circuit for
		Analytical Instrument Applications
9956	EE	(Conder) Vertically Phased MOS Electrode
		Structures for Change Storage in Semiconductors
9957	C&MS	(Fox) Increased Solubility of Elctro-Luminescent
	•	Polymers Via Addition of Radical Initiators
9959	C&MS	(Stevens) Optical Pumping for Remote Chemical
	,	Sensing
9965	Lasers	(Beach) Laser Roads with Undoped, Flanged End-
		Cans for End-Pumped Lagar Applications
9977	C&MS	Caps for End-Pumped Laser Applications (Stevens) Signal Processing by Minimization of Residual Complexity
		and the contract of the contra

9979	MFE	(Post) Improved Passive Stabilizer for Rotor-
9980	Physics	Dynamic Instabilities (Bernhardt) Electron Injecting Electrode for
9985	EE	Organic Electroluminescent Displays
9990	C&MS	(Yu) High Temperature Sample Injector
<i>7770</i>	CONIS	(Zundelevich) Two-Stage Acidic Urea DeNOx
9994	Lagana	Process in Self-Aerated Gas-Liquid Contactors
	Lasers	(Freitas) Layered Laser Diode Array
9997	Lasers	(Cartland) Stagnation Pressure Activated Fuel
		Release Mechanism for Hypersonic Projectiles
10001	C&MS	(Coburn) Electrochemical Production of
		Nitromethane from Acetic Acid
10004	C&MS	(Watkins) A Top Injection System for Processing
•		Explosives
10010	Physics	(van Bibber) An Energy-Loss Camera for Proton
•	-	Radiography Based on Near-Threshold
10012	Physics	(Bennett) Phase Chirped Imaging Fourier
		Transform Spectrometer
10017	EE	(Wilhemsen) Hazard Avoidance Limiter for
		Telerobotics
10022	ME	(Logan) High-Resolution Detector for Digital
		Imaging with High Engage V Dans
10023	Lasers	Imaging with High-Energy X-Rays
10023	Lasers	(Vann) Tiered Diode Array
10054	Lasers	(Colston) Optical Coherence System for Measuring
10037	Lasers	Ice Buildup on Airplane Surfaces
10057	Lasers	(Freitas) Ruggedized, Microchannel-Cooled Laser
10043	C&MS	Diode Array
10043	CœMS	(Fox) Functionalization of Soluble Polymers by
•		Covalent Attachment of Luminescent and
10045		Electroluminescent Molecular Units
10045	EE	(Leach) Process for Automatic Indication of Need
		for Natural Gas Storage Well Remediation
10047	BBRP	(Ophoff) Mutations in CACNL 1A4 Associated
•		with Familial Hemiplegic Migraine
10050	C&MS	(Upadhye) A General Purpose Molten Salt
		Destruction Equipment
10052	Physics	(Erskine) Probabilistic Encryption by Scrambled
	•	Partial Coherence of Noise
10057	C&MS	(Glass) Sensor-Based System for Minimization of
	. •	Neurological Damage Resulting from Stroke or
		Other Brain Trauma
10063	Physics	(Roeske) Fast, A1-Coated PIN Diagnostic
10072	Physics	(Netel) High-Resolution X-Ray and Y-Ray
	1,010	Spectrometer Recod on Light 7 Tilling D
10074	EE	Spectrometer Based on High-Z, Ultra-Pure
100/1	.	(Mullenhoff) Tongue Antenna

10075	C&MS	(Reynolds) Method of Separating Olefins from Mixed Hydrocarbon and Refinery Gas Streams
10079	Lasers	Using Metal Nitrides (Freitas) High-Brightness, High Power, Quasi- Monolithic Diode Array
10081	Lasers	(Burnett) Noise Reduction Em Sensor and Acoustic Algorithms
10082	Lasers	(Burnett) New EM Sensor/Acoustic Electronic and Numerical Algorithms
10086	Physics	(Bernhardt) Process for Fabrication of a Microrelay
10094	Physics	(Erskine) Solid-Angle Independent High
	- 11,0100	Resolution Spectrometer
10096	Lasers	(Shafer) Mirror Systems for EUV
10101	Lasers	(Stone) Vacuum Sealing Technique for an X-Ray
		Microtube
10104	C&MS	(Tillotson) Method for Preparing Transparent
		Alumina Aerogels
10105	C&MS	(Hrubesh) Vanadia-Silica Aerogel Fast Sensing
		Detector-Desiccant
10106	Physics	(Erskine)Wavelength Resolving Coherence
		Multiplexing for High Speed Fiber Optic
		Communication
10107	Physics	(Erskine) Two-Delay Interferometer and
		Application to Spectrometry
10108	Physics	(Erskine) Prejudicial Presentation of Sources to
•		Anticipate Fiber-Optic Dispersion
10109	EE	(Yu) Low Porosity Silicon Nitride Films
10114	Lasers	(Darrow) A Passive Device for Indication of
		Rotational Orientation of Medical Device
10116	C&MS	(Pagoria) High Performance Explosive Molecules
10119	EE	(Kallman) Mechanoluminescent Acoustic Field
10105		Sensor
10135	Physics	(Erskine) Retarding Superimposing
10107	-	Interferometer Configurations
10136	Lasers	(Vann) Laser Shadow Sensor for Measuring Fluid
10140	Trans. Cal	Level in an Open Vessel
10149	Env. Sci.	(Vogel) Device and Method for Single-Use
10150	T	Container-Controller-Ionizer for Gas Samples
10150	Lasers	(Estabrook) Improved Spatial Filter for High
10161	Lacore	Power Lasers
10101	Lasers	(Vann) Parallel Optical Signal Transmission and
10163	Env Sci	Reception System (Molitaria) Cross Carity Rejection (V. V.
10103	EIIV SCI	(Molitoris) Cross-Cavity Reinjection for Laser
10168	Physics	Heterodyne Amplification (Erskine) Delay-Free Differential Interferometric Spectrometer

10172	EE	(Swierkowski) Dual Flow F Load for
10177	Lasers	Microcapillary Fluidic Injection Systems (Toeppen) Holographic Recording and Inspection
10180	C&MS	of Optical Systems (Fox) Thio-, Amine, Nitro and Macrocyclic
10182	Physics	Containing Organic Aerogels (Koo) Measurement of Water Content by Pico-
10183	Lasers	Second Electromagnetic Pulse Technology (Everett) Method for Marking or Etching of Images into a Metal Surface Using a Laser
10185	ME	(Hale) Differential Friction Drive for Precision Rotary Applications
10188	EE	(Miles) A Hydraulically Amplified PZT MEMS Actuator
10189	EE	(Miles) A Fluidic System Based on Monolithic Tubes and Plenums
10202	Lasers	(Fernandez) Method for Optimizing Multiple- Beam Interference Patterns for Lithography
10203	P&ST	(Marrs) An X-Ray Microscope Powered By Highly Charged Ions
10204	Physics	(Cox) Dynamic Monte Carlo Optimization of Intensity Modulated Radiotherapy
10207	Lasers	(Da Silva) Tapered Fiber Optics via Multiple Heat Shrink Wrapping for Endovascular Steerability
10220	C&MS	(Coronado) Rapid Process For Producing Transparent, Monolithic Porous Glass
10222	Lasers	(Spallas) A Tunnel Junction Spin-Valve Transistor
10224	Lasers	(Carey) Read/Write Head Having a GMR Sensor Biased by Permanent Magnets Located Between the GMR and the Pole Shields
10229	C&MS	(Coronado) Method for Preparing Precursors for Producing Monolithic Metal Oxide Aerogel with
10235	JPO-100- Engineerin g-0	Densities Between 0.3g/cc to 1.5g/cc (Haddad) Endoscope Optical Isolation
10237	Lasers	(Freitas) Low-Cost, High-Registration, Monolithic Laser Diode Array with Removal Spring
10239	Lasers	(Page) All-Solid-State Tunable Visible Laser Source Using Sum-Frequency-Mixing or Frequency Doubling of a Yb:Silica Fiber Laser and
10280 CR	Energy	a n Nd:YAG Laser (Folta) High-Speed, Low-Power Thermopneumatic Microfabricated Actuator using the Insulated-Piston Approach

10308	Energy	(Post) Improved Version of High-Power Halbach-Array Generator/Motor
10312	BBRP	(Olsen) Nephrin Gene and Protein
10318	Lasers	(Haddad) Method for Transmission-mode
		Ultrasonic Tomography
10319	Lasers	(Haddad) Method for Reflection-mode Ultrasonic
	•	Tomography
10320	ENG	(Wieskamp) Compact Asymmetric Blumlein
		Flash X-Ray Source
10321	ENG	(Thomas) Últrasonic Breast Imaging System
10322	ENG	(Candy) Compensated, Individually Addressable
	•	Array Technology
10323	ENG	(Candy) Dynamic Focusing of Ultrasound for
	•	Mass Removal in Tissue
10330	ENG	(Miles) Hydrodynamic Enhanced
		Dielectrophoretic Particle Trapping
10331	ENG	(Miles) Movement of Particles using Sequentially
		Activated Dielectrophoretic Particle Trapping
10333	NAI	(Madden) Actively Driven Thermal Radiation
		Shield for a Mechanically Cooled Portable
	•	Germanium Gamma-Ray Spectrometer
10334	Lasers	(Bajt) A Technique to Quantitatively Measure
		Magnetic Properties of Thin Structures at <10 nm
		Spatial Resolution
10335	JPO-100-	
	JI O 100	(Makalewicz) Laser and Acoustic Lens for
	•	(Makarewicz) Laser and Acoustic Lens for Lithotripsy
	Engineerin	Lithotripsy
10342	•	Lithotripsy
	Engineerin g-0	Lithotripsy
	Engineerin g-0 JPO/D&NT	Lithotripsy (Bearinger) Injectable Sensor
10342	Engineerin g-0 JPO/D&NT /Lasers	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and
10342 10346	Engineerin g-0 JPO/D&NT /Lasers D&NT	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers
10342	Engineerin g-0 JPO/D&NT /Lasers	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated
10342 10346	Engineerin g-0 JPO/D&NT /Lasers D&NT	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output
10342 10346 10352	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom
10342 10346 10352	Engineerin g-0 JPO/D&NT /Lasers D&NT	Lithotripsy (Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output
10342 10346 10352	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces
10342 10346 10352 10357	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography
10342 10346 10352 10357	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve
10342 10346 10352 10357 10359 10363	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet
10342 10346 10352 10357 10359 10363 10364	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary
10342 10346 10352 10357 10359 10363	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary (Koo) Paper Area Density Measurement from
10342 10346 10352 10357 10359 10363 10364 10365	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI NAI Energy	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary (Koo) Paper Area Density Measurement from Forward Transmitted Scattered Light
10342 10346 10352 10357 10359 10363 10364 10365 10367	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI NAI Energy D&NT	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary (Koo) Paper Area Density Measurement from Forward Transmitted Scattered Light (Kirbie) Compact Pulsed Power Source
10342 10346 10352 10357 10359 10363 10364 10365 10367 10368	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI NAI Energy D&NT	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary (Koo) Paper Area Density Measurement from Forward Transmitted Scattered Light (Kirbie) Compact Pulsed Power Source (Caporaso) Improved Compact Accelerator
10342 10346 10352 10357 10359 10363 10364 10365 10367	Engineerin g-0 JPO/D&NT /Lasers D&NT D&NT Engineerin g Lasers NAI NAI Energy D&NT	(Bearinger) Injectable Sensor (McCarthy) An Etch Sequence for Thin and Smooth Silicon Wafers (Frank) Laser Initiated Detonator with Rotated Detonation Output (Carr) Atmospheric Pressure Reactive Atom Plasma Processing for Shaping of Damage Free Surfaces (Perry) Laser Radiography (Seward) Shape Memory Bimorph Microvalve Actuator Created from Ti-Ni Sheet (Yu) A Thin Film Capillary (Koo) Paper Area Density Measurement from Forward Transmitted Scattered Light (Kirbie) Compact Pulsed Power Source

10373		(Miles) Stepped Electrophoresis for Movement
10374	g Engineerin	
10380	g C&MS/NA	DNA Sample Preparation (Andresen) Porous Protective SPME Sheath
10385	EUVL	(Sweatt) Condenser Design for Extreme-UV Ring Field Lithography Camera
10387	P&ST	(Wolfe) Reflective Coating for Radiation Protection during Processing
10390	BBRP	(McCready) A Novel Dye Terminator Protocol for DNA Sequencing
10392	C&MS or	(Farmer) Electrolytic Cells with Fluidized-bed,
	Environm	Moving-bed, Slurry, and Moving-belt Electrodes
	ental	for Water Purification, Desalination, Waste Treatment and Air Purification
10393	D&NT	(Schnittker) Wide-Band Multi-Crystal Oscillator
10394	NAI	(Yu) Hand-Held Multiple System Gas
		Chromatograph
10399	D&NT	(Hill) High Temperature Source for Generating Atomic/Molecular Beams of High Intensity and Variable Kinetic Energy
10404	Engineerin	(Miles) Use of Impedance Measurements to Detect
	g	the Presence of Pathogens Trapped in Electric Field
10407	D&NT	(Perry) Ultrashort-Pulse Laser Machining System Employing a Parametric Amplifier
10410	Engineerin	(Simon) Broad Spectrum Biological Pathogen
	g	Detector & Instrumentation
10411-	Lasers/EU	(Hale) Projection Optics Box
CR	VL	
10413	C&MS	(Hrubesh) Method for Producing Lightweight, High Strength Carbon Aerogel Composites
10415	Engineerin	(Miles) DNA Sizing using Selective
	g	Delectrophoretic Trapping or an Isomotive Electrode Set
10416	Engineerin g	(Miles) Use of Impedance Measurements to Detect the End-Point for PCR DNA Amplification
10418	Engineerin g	(Logan) A Method for Employing the Substrate of an Active Matraix Flat Panel Imaging Array to Imaging Advantage when Imaging High-Energy
		X-Rays
10426	D&NT	(Avalle) Distributed Accelerometer Inertial Measurement Unit

10429	Engineerin	(Jankowski) MEMS-Based Thin-Film Fuel Cells
	g	for Electrical Power Pack Applications
10434	g P&ST	(Erskine) Fringing Spectroscopy for Precision
		Long-baseline Interferometry
10441	E&ES	(Bogen) A Microelectromechanical ("MEMpette")
		Device for Sorting and Counting Particles (or
		Cells) in One or More User-specified Sizes from a
		Liquid Sample and for Dispensing These Particles
		in User-specified Numbers
10442	E&ES	(Bogen) Microelectromechanically Integrated
20112	ب	Nanowell Array Biochip Device for Rapid and
		Efficient Isolation, Manipulation, and Culture of
	•	Single Cells, and for Related Analysis
10445	JPO/Lasers	(Satcher) Novel Fluorescent Compounds for
10110	JI O/ Ediscis	Quantification of Physiological Analytes such as
		Glucose
10457	Energy	(Post) Improved Passive Magnetic Bearing
10437	LiterBy	Configuration
10463	Lasers	(Wilkins) Scanning Phase Knife for Wavefront
10405	Lasers	Slope and Defect Measurement
10466	Engrav	•
10400	Energy	(Post) Magnetic Bearing Element with Adjustable Stiffness
10473	Enginossia	•
104/3	Engineerin	(Benett) Integrated Miniature Electrical
	g	Interconnects for Microelectromechanical and
10477	Eii-	Microfluidic Systems
10477	Engineerin	(Larson) Post-growth Digital Wavelength Tuning
•	g	of Vertical Cavity Surface-Emitting Lasers by
10400	T7	Selective Lateral Oxidation
10488	Engineerin	(Deri) Compact Multiwavelength Transmitter
10510	g	Module for Multimode Fiber Optic Ribbon Cable
10518	Other	(Alford) Livelink API Management System

Advisor: BUD CARNAHAN

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

10428 BBRP

(Davidson) Modified Electrokinetic Sample Injection in Chromatography and Electrophoresis Analysis. Application sent PTO Express Mail 8/23/99.

CIP Application

Continuation/Divisional Application:

9609C

(Makowiecki) Divisional Application sent PTO

Express Mail 8/23/99

9859B

(Coronado) Divisional Application sent PTO

Express Mail 8/23/99

PCT Application

Applications in	Preparation:	
10146B	Lasers	(Trebes) Miniature X-Ray Source
		(Division)(Dispute - on hold)
10333	NAI	(Madden) Actively Driven Thermal Radiation
		Shield for a Mechanically Cooled Portable
•		Germanium Gamma-Ray Spectrometer
10365	Energy	(Koo) Paper Area Density Measurement from
•		Forward Transmitted Scattered Light
10394	NAI	(Yu) Hand-Held Multiple Sustem Gas
•		Chromatograph

	10401	EE	(Simon) Apparatus for Collection of Respirable Particles		
	10427	Engineering	Micromachined Low Frequency Rocking Accelerometers with Capacitive Pickoff Fabricated by Deep Reactive Ion Etching		
٠.	10446	NAI	(Ivanov) Fissile Material Detector		
	10494	P&ST	Electroless Epitaxial Etching for Semiconductor		
	10171	1001	Applications		
	10543	NAI	(Koo) Glow Discharge Detector		
Prose		to DOE or P			
	9193C	(Lee) Firs 8/25/99	t Office Actionresp due 9/22/99. Resp sent PTO		
	9193D		t Office Actionresp due 9/22/99. Resp sent PTO		
	9306	•	rst Office Actionresp due 9/23/99. Resp sent PTO		
	0266 CBA		Einst Office Action room due 8/28/00 Posm sont		
•	9366 CPA	PTO 8/25	•		
	961 7 B	(Nathel) 1 PTO 8/25	First Office Actionresp due 9/10/99. Resp sent		
	9707B (Northrup) Office Action, Prosecution Reopenedresp 8/26/99. Resp sent PTO 8/25/99				
•	9707C	(Northru	p) Office Action, Prosecution Reopenedresp due Resp sent PTO 8/25/99.		
	9850		Decision of Appealresp due 9/19/99. Resp sent		
•	9886		irst Office Action-resp due 9/17/99. Resp sent PTO		
,	9897	(Morse) F	First Office Actionresp due 9/9/99. Response with on sent to PTO 8/27/99		
	9936	(Wieskan	np) Final Office Actionresp due 10/16/99. Resp 8/25/99.		
	9949		est Office Actionresp due 9/8/99. Resp sent PTO		
	9962	(Northruj month ex	o) Notice of Appealresp due 8/13/99 w/two tension. Filed CPA w/two month extension fail 8/4/99		
	10027		ki) First Office Actionresp due 9/25/99. Resp sent		
	10251	· ·	n) First Office Actionresp due 9/28/99. Resp sent		
·	10268		t Office Actionresp due 10/16/99. Resp sent PTO		

10298	(Hale) Notice of Allowance, Notice of Allowabilityresp
	due 8/27/99. Issue Fee and Formal drawings sent PTO
	8/26/99.
10307	(Spiller) First Office Actionresp due 9/8/99. Resp sent PTO
	with additional fee 8/27/99.
10372	(Bajt) First Office Action-resp due 10/2/99. Resp sent PTO
	8/25/99.

<u>Per</u>	<u>iding Prosec</u>	ution:
	9032	(Aines) Notice of Allowance, Notice of Allowabilityresp due 9/21/99
	9276	(Buettner) Notice of Allowance, Notice of Allowabiltyresp due 10/1/99
	9398C	(McCarthy) Final Office Action-resp due 10/21/99
	9398C	(McCarthy) Notice of Appeal-resp due 10/19/99
	9402B	(McCarthy) Final Office Action-resp due 11/3/99
	9402B	(McCarthy) Notice of Appeal-resp due 11/1/99
	9451B	(Jankowski) Advisory Actionresp due 11/10/99.
	9651	(Carrigan) Notice of Allowance, Notice of Allowability-resp
		due 9/9/99. Issue Fee and drawings sent PTO 9/1/99
	9561	(Hale) Final Office Actionresp due 10/27/99
	9561	(Hale) Notice of Appealresp due 10/25/99
	9637B	(Makowiecki) Second Office Actionresp due 11/12/99
,	9705	(Musket) First Office Actionresp due 10/26/99
	9713	(Van Konynenburg) Notice of Allowance, Notice of Allowabiltiyresp due 10/7/99
	9730	(Davidson) Notice of Allowance, Notice of Allowability resp due 10/1/99
	9732	(Davidson) Final Office Actionresp due 11/24/99
	9732	(Davidson) Notice of Appealresp due 11/24/99
	9767	(Blaedel) Decision on Appeal 6/25/99. Contact Examiner if no further action by 9/25/99.
	9814B	(Carey) First Office Actionresp due 10/30/99
•	9853	(Andresen) Advisory Actionresp due 9/13/99. Response was to file CPA 9/1/99.
	9854	(Andresen) Notice of Allowance, Notice of Allowability

(Morse) Final Office Action—resp due 11/2/99 (Morse) Notice of Appeal—resp due 10/31/99

(Wieskamp) Notice of Appeal--resp due 10/14/99

resp due 10/6/99

due 11/4/99

9873

9895B

9895B 9913

9936

resp due 9/8/99. Issue Fee and drawings sent PTO 9/1/99

(Krulevitch) Notice of Allowance, Notice of Allowability--

(Musket) Notice of Allowance, Notice of Allowability--resp

9951	(Kare) Notice of Allowance, Notice of Allowabilityresp due 9/30/99.
10007B	(Northrup) Notice of Allowance, Notice of Allowabilityresp due 11/24/99. Supplemental Notice of Allowabilityresp due11/24/99.
10024	(Brown) Final Office Actionresp due 11/10/99
10024	(Brown) Notice of Appealresp due 11/8/99
10029	(Frank) Notice of Allowance, Notice of Allowabilityresp due 11/2/99
10048	(Davidson) Notice of Allowance, Notice of Allowability-resp due 11/2/99
10062	(Chaiken) Appeal Brief due 9/28/99
10088	(Dinh) Notice of Allowance, Notice of Allowabilityresp due 10/14/99
10117	(Carey) Notice of Allowance, Notice of Allowabilityresp due 10/14/99
10118	(Kallman) First Office Action-resp due 11/25/99
10130	(Pham) Final Office Actionresp due 11/27/99
10130	(Pham) Notice of Appealresp due 11/25/99
10159	(Krulevitch) Final Office Actionresp due 11/5/99
10159	(Krulevitch) Notice of Appealresp due 11/3/99
10210	(Mirkarimi) Notice of Allowance, Notice of Allowability
	resp due 9/10/99. Issue Fee sent PTO 9/1/99.
10300	(Benett) First Office Actionresp due 11/10/99
10332FOR	PCTresp due 9/21/99 (Bud and Nancy notified). Request sent PTO 9/1/99
10332FOR	Demandresp due 10/21/99 (Bud and Nancy notified)
10347FOR	PCT and Demandresp due 10/26/99 (Bud and Nancy notified).
10349FOR	PCT and Demandresp due 10/26/99 (Bud and Nancy notified).

Advisor: DARYL GRZYBICKI

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

10257 Env.

(Knauss) Hyperbaric Hydrothermal Atomic Force Microscope--SENT PTO 8/3/99

CIP Application

Continuation/Divisional Application:

PCT Application

Preparation:	
C&MS	(Miller) Advanced Multi-Toxic Detection and
	Filtering System
C&MS	(Miller) Use of Treated Aerogel (for Chemical
	Specific Absorption) as a Sample Collection Media
ME	(Berg et al.) Aerogel Composites for High
	Temperature Insulation and Fire Retardation
Other	(Andresen) A New Kovar, Wire Fiber Solid Phase
	Micro Extraction (SPME) Device
Lasers	(Law) Ultra-High Density Hollow Magnetic Sensor
C&MS	(Fox) Metals Removal from Waste Streams Using
•	Polymer Pendant Sulfur Complexes
C&MS	(Fox) Metals Removal from Waste Streams using
	Extraction with Sulfur Ligands
NAI	(Hoffman) Oxidizer Gels for Detoxification of
	Chemical and Biological Agents
	C&MS ME Other Lasers C&MS C&MS

			•
	10281	EE	(Folta) Conformal Chemically Resistant Coating for Microflow Devices
٠.	10341	JPO	Long Wavelength Intramolecular Fluorescence Switching Sensor for Measuring and Analyte such
	10370 10379	LAS JPO/	as Glucose (Colston) Hand-held Dental Imaging Device (Everett) Birefringence Insensitive OCDR System
	10435	Engineering JPO	(Darrow) Fluorescence Lifetime Assay for Non- Invasive Quantification of Physiological Analytes
	10490	JPO/Lasers	such as Glucose (Brown) Method for Creating Chemical Sensors
	10496	JPO/Lasers	Using Microjet Technology (Darrow) A Device for the Detection of
	10516	BBRP/NAI	Birefringement Micro-Crystals in Bile (Kadhodayan) Antidotes to Bacterial Toxins
Prose	cution Sent	to DOE or PI	<u>:O:</u>
	9615	(Weihs) R PTO 8/23	estriction Requirementresp due 8/26/99SENT
÷.	10252		Notice of Allowance, Notice of Allowabilityresp 9SENT PTO 8/9/99
	10252	(Sweeney)	Amendment After FinalSENT PTO 8/9/99
•	10253	(Haas) An	nendmentresp due 8/25/99SENT PTO 8/25/99
- TO: 11	Dunner	·	
Pendi	ng Prosecut 8860	<u>(Vu) Final</u>	Office Actionresp due 10/28/99
	8860	(Yu) Notic	ce of Appeal-resp due 10/26/99
	9761C	(Tu) None	ppeal Brief-resp due 9/29/99 w/one month
	<i>57</i> 01C	extension	
	9805		Jotice of Allowance, Notice of Allowabilityresp
	7000	due 11/9/	
	9892	(Poco) Fin extension	al Office Actionresp due 9/15/99 w/one month .
	9892	extension	
	9904	extension.	st Office Actionresp due 9/5/99 w/eight month Notice of Abandonment dated 5/11/99.
	9904FOR		resp due 10/13/99 (DG notified)
	9950		otice to file Missing Partsresp due 10/11/99.
	10035	due 11/16	
•	10066FOR		Filingresp due 9/3/99 (DG notified)sent to arry (5/24/99) to prepare (per DG's request, lnh)
	10122		First Office Actionresp due 11/25/99

10208	(Sommargren) Notice of Allowance, Notice of Allowability-resp due 10/6/99.
10221	(Cooper) First Office Actionresp due 10/8/99.
10252FOR	Demandresp due 9/19/99 (Sent Fax requesting Ladas &
	Parry to prepare Demandper DG (lnh)
10252B	(Sweeney) Final Office Actionresp due 9/27/99 w/two
	month extensionsent to Paul Tomita (Dergosits) to prepare
	(sent on 5/7/99)
10263	(Chapman) Notice of Allowabilityresp due 9/3/99SENT
	PTO 9/3/99. Notice of Allowance resp due 9/15/99SENT
	PTO 9/3/99. (Note prior NOA 9/3/99 date)
10313	(Montcalm) First Office Actionresp due 10/30/99
	•

Misc. Projects Completed

Pending

Advisor: JOHN WOOLDRIDGE

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

CIP Application

Continuation/Divisional Application:

PCT Application

Applications in Preparation:

9928	NAI	(Ruggiero) Integrated Optical Capillary
40000	_	Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile
		Parametric Wavelength Convertor
10078	Lasers	Monolithic Microchannel-cooled V-groove
		Microlensed Laser Diode Array
10209	Lasers	(Sommargen) Application of the PSDI for
		Measuring Convex Mirrors and Negative Lenses
10223	P&ST	(Frank) High-Resolution, Cryogenic X-Ray
	•	Detector With High Count Rate Capability
10334	Lasers	(Bajt) A Technique to Quantitatively Measure
•		Magnetic Properties of Thin Structures at <10 nm
		Spatial Resolution
10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery
	-	with an Echo-Contrast Agent

	10366	Lasers	(Banks) Method to Reduce Damage to Backing
			Plate using Prepulse
	10391	Lasers	(Ishikawa) Gamma Watermarking
	10398	Lasers	(Rushford) Optical Monitor for Real Time
		•	Thickness Change Measurements
	10417-	Lasers	(Beach) Design for Delivering Pump Light to a
	CR		Laser Gain Element while Maintaining Access to
			the Laser Beam
	10447	Lasers	(Ishikawa) Composition Analysis by Scanning
			Femtosecond Laser Ultraprobing (CASFLU)
	10459	Lasers	Coherent Beam Combiner for a High Power Laser
	10483	Lasers	(Hackel) Ablation and Insulation Layer for Laser
•			Peening
	10520	Lasers	(Wilcox) Antiguided Fiber Ribbon Laser
	10530	Lasers	(Sommargren) Inspection of Lithographic Mask
		• .	Blanks for Defects
	10558 CR	Lasers	(Hackel) Contour Forming of Metals by Means of
			Laser Peening

Prosecution	•		$\mathbf{D} \cap \mathbf{F}$		DTC
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'	9444	(Mariella) First Office Actionresp due 8/24/99 (three
	7	month extension). Resp sent 8/24/99
	9493B	(Toeppen) Notice of Appeal sent 8/22/99 (three month extension)
	9581	(Vernon) Notice of Allowance, Notice of Allowabilityresp due 9/21/99. Issue Fee sent 8/27/99. Formal Drawings sent 8/30/99.
	9689	(Sheem) First Office Actionresp due 8/5/99 (three month extension). Resp sent 8/5/99.
	9869	(Celliers) Notice of Allowance and Notice of Allowability-resp due 8/24/99. Resp sent 8/23/99.
	9912	(Kyle) Final Office Actionresp due 8/10/99 (three month extension). Resp sent 8/10/99.
	10031	(Matthews) Notice of Allowance, Notice of Allowability resp due 8/28/99. Resp sent 8/26/99
	10142A	(Vann) Second Office Action-resp due 8/9/99 (three month extension). Resp sent 8/9/99.
	10142B	(Vann) Final Office Actionresp due 8/9/99 (three month extension). Resp sent 8/9/99.
	10244	(Stuart) Notice to File Missing parts—resp due 8/20/99 (one month extension). Resp sent 8/17/99
	10326	(Banks) Notice to File Missing Partsresp due 8/15/99. Resp sent 8/13/99

Pone	ling Prosecuti	ion:
renc	_	(Jones/Post) Appeal Brief with Petition to Reviveresp due
	9044	9/21/99
	9493B	(Toeppen) Appeal Briefresp due 10/22/99
	9566B	(Perry) Final Office Actionresp due 9/4/99
	9566B	(Perry) Notice of Appeal-resp due 9/4/99
	9567FOR	(McEwan) European office actionresp due in Europe
		9/5/99 (due to L/P before 9/5).
	,	THIS IS NOT EXTENDABLE.
	9676	(Holzrichter) Notice of Allowance, Notice of Allowability
		resp due 9/28/99
	9762	(Burkhart) Final Office Actionresp due 10/30/99
	9762	(Burkhart) Notice of Appealresp due 10/28/99
	9860	(Hackel) Third Office Actionresp due 9/5/99. (three month
	,	extension)
	9889	(Rogalski) First Office Actionresp due 9/17/99. (three
	00	month extension)
	9912	(Kyle) Notice of Allowance, Notice of Allowabilityresp due
		11/26/99
-	9926	(Post) First Office Actionresp due 10/1/99.
	9967	(Goerz) First Office Actionresp due 9/27/99 (two month
		extension)
	9969	(Regents) Notice to File Missing Parts (US national stage)
		resp due 9/2/99 (two month extension). Ladas & Parry will
		file this. TC sent to L/P on 8/5/99.
	10000	(Erskine) Final Office Actionresp due 9/15/99 (one month
		extension)
	10000	(Erskine) Notice of Appealresp due 9/15/99 (one month
		extension)
	10038	(Small) John wants to file a CIP by or on 11/16/9 (before or
		on date of paying issue fee)
	10038	(Small) Notice of Allowance, Notice of Allowabilityresp
		due 11/16/99
	10126	(Perry) Final Office Actionresp due 9/18/99 (three month
		extension).
	10126	(Perry) Notice of Appealresp due 9/16/99 (three month
		extension).
	10167	(Hackel) First Office Action-resp due 10/12/99.
	10170	(Vann) First Office Actionresp due 10/22/99
	10225	(Visuri) First Office Actionresp due 9/30/99 (three month
		extension).
	10304FOR	PCT Application and Demandresp due 9/15/99 (JW and
	:	TC notified)
	10340	(Freitas) Notice to File Missing Partsresp due 10/18/99

10351 (Yang) Preliminary Amendment to cover deleted itemsresp due 9/22/99

10351FOR Provisional Filing and Demand--resp due 9/10/99 (JW and
TC notified)

10549 Trademark -- Peregrine Dose Calculation Engine. Notice of
Allowance -- resp due 11/4/99

10550 Trademark -- Peregrine 3-D Monte Carlo. Notice of
Allowance -- resp due 11/4/99

Misc. Projects: Completed

Pending

Advisor: ALAN THOMPSON

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

CIP Application

Continuation/Divisional Application:

Applications in	Preparation:	
9935B	D&NT	(Haigh) High Voltage Photovoltaix Power
		Converter
10256	Engineering	(Miles) Streamline Separation of Cells Using
	/ BBRP	Dielectrophoretic Force
10283	C&MS	(Musket) Formation of Nanometer-Size Wires
•		Using Infiltration into Latent Nuclear Tracks
10367	D&NT	(Kirbie) Compact Pulsed Power Source
10368	D&NT	(Caporaso) Improved Compact Accelerator
10369	D&NT	(Sampayan) Compact Pulsed Lithography System
10420	Energy	(Post) A Combined Passive Magnetic Bearing
	0,	Element and Vibration Damper
10437	Environmental	(Berryman) Robust Discrimination of Porosity
		and Fluid Saturation using Seismic Velocity
	•	Analysis

10489 Environmental (Leif) Increasing Effective Water Solubility of

Organic Contaminants and Petroleum by

Aqueous Thermal Oxidation

10534 Energy (Hunter) Rotational Rate Sensor

Prosecution Sent to DOE or PTO:

Pending Prosecution:

8737 (DeTeresa) New Final Office Action--resp due 11/17/99.
9958 (Hagans) First Office Action--resp due 9/7/99.
10206 (Bennahmias) Notice to File Missing Parts--resp due 10/12/99.
10271 (Penetrante) First Office Action--resp due 11/13/99.
10275 (Penetrante) First Office Action--resp due 11/16/99

Misc. Projects: Completed

Pending

Advisor: LLOYD DAKIN

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

10265 Energy

(Hernandez) System and Method for 100%

Moisture and Basis Weight Measurement of Moving paper--SENT PTO 8/30/99 (lnh)

CIP Application

Continuation/Divisional Application:

Applications in Preparation:	
10082 DO	(Burnett) New EM Sensor/Acoustic Electronic and
	Numerical Algorithms
10318 ГРО/	(Haddad) Method for Transmission-mode
Engineering	Ultrasonic Tomography
10319 JPO/	(Haddad) Method for Reflection-mode Ultrasonic
Engineering	Tomography
10321 ГРО/	(Haddad) Ultrasonic Breast Imaging System
Engineering	
10360 NAI	(Coffland) Random Number Generator for Real-
	Time Media Encryption
10400 Energy	(Hunter) Tiltmeter Leveling Mechanism
10409 Energy	(Hunter) Self Adjusting Inclinometer
10443 Computation	DataFoundry Software

10524

BBRP

(Kuczmarski) MPGSS (Massively Parallel

Genomic Similarity Search)

10557

EE

(Carlisle) Two Coordinate Measuring System

Prosecution Sent to DOE or PTO:

10147FOR

PCT--resp due 8/7/99 (Lloyd notified)--SENT PTO 8/3/99

10147FOR

Demand--resp due 9/3/99 -- SENT PTO 8/25/99 (lnh)

Pending Prosecution:

9578

(Strait) Notice of Allowance, Notice of Allowability--resp

due 10/19/99. Supplemental Notice of Allowability--resp

due 10/19/99.

10085

(Bernhardt) First Office Action--resp due 11/23/9

10147FOR

Invit to Correct Defects—resp due 9/25/99

10147FOR 10200FOR

Notice to Correct Defects--resp due 9/18/99.

10219

(Fullerson) First Office Action--resp due 9/23/99 w/two

month extension

10350FOR

PCT and Demand--resp due 11/12/99 (Lloyd notified)

10469

(Vanarsdall) DOE requests formal invention disclosure--

resp due 4/30/99.

Misc. Projects: Completed

Pending

Advisor: FARM OUT

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

CIP Application

Continuation/Divisional Application:

PCT Application

Applications in Preparation:

10395 Lasers (Chapman et al) DG sent request to Dergosits &

Noah (8/9/99) to prepare estimate to prepare CIP.

10516 BBRP (Kadkhodayan et al) Antidotes to Bacterial

Toxins..7/8/99 requested Wilson Sonsini to prepare Application and IDS per DG (lnh).

Prosecution Sent to DOE or PTO:

9257B (Lucas) First Office Action Sent To Wilson Sonsini to

prepare--resp due 10/2/99. Resp sent PTO by Wilson

Sonisini 8/27/99

10011 (Satcher) Notice of Allowance, Notice of Allowability--resp

due 10/20/99--resp sent by Townsend & Townsend on

8/9/99

Pending Prosecution:

8567A FOR (Turtletaub) First Office Action -- resp due 10/29/99

9091FOR (McEwan) Second Office Action--resp due 11/16/99.

9509	(Barbee) Office Action in Reexamination -resp due 10/11/99
	(Wilson Sonsini is preparing per DG)
9567FOR	(McEwan) First Office Actionresp due PCT/Europe 9/5/99
	w/two month extension. (Ladas & Parry)
10210FOR	Demand-resp due 9/19/99 (DG sent request to Ladas &
	Parry on 8/10/99 to prepare Demand)
10226	(Visuri) First Office Action file by Majestic, Parsonsresp
•	due 9/26/99 w/one month extension.
10251FOR	Demandresp due 9/19/99 (DG sent to Ladas & Parry for
	preparation)
10297FOR	PCT Applicationresp due 9/30/99 (DG sent ltr to Ladas &
	Parry on 8/23/99 requesting they prepare PCT Application)
10307FOR	PCT Applicationresp due 9/25/99 (DG sent ltr to Ladas &
	Parry on 8/23/99 requesting they prepare PCT Application)



CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:	UC	Applications	Submitted
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10223 P&ST (Frank) A Cryogenic, High-Resolution X-Ray

Detector With High Count Rate Capability

(Beach) Design for Delivering Pump Light to a 10417-Lasers CR

Laser Gain Element while Maintaining Access to

the Laser Beam

CIP Application

Continuation/Divisional Application:

PCT Application

10304FOR JPO/Lasers (Haddad) Microwave Hematoma Detector 10351FOR Physics (Yang) FALCON: Automated Optimization Method for Arbitrary Assessment Criteria

Applications in Preparation:

	T T T T T T T T T T T T T T T T T T T	
9928	NAI	(Ruggiero) Integrated Optical Capillary
		Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile
		Parametric Wavelength Convertor
10078	Lasers	Monolithic Microchannel-cooled V-groove
		Microlensed Laser Diode Array
10209	Lasers	(Sommargen) Application of the PSDI for
		Measuring Convex Mirrors and Negative Lenses
10334	Lasers	(Bajt) A Technique to Quantitatively Measure
		Magnetic Properties of Thin Structures at <10 nm
		Spatial Resolution

Monthly Report Worksheet For the Period

October 1, 1999 to October 31, 1999

Advisor: JOHN WOOLDRIDGE

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

10078 Lasers

Monolithic Microchannel-cooled V-groove

Microlensed Laser Diode Array

10605 Copyright Copyright application mailed 10/13/99.

PEREGRINE

CIP Application

Continuation/Divisional Application:

PCT Application

10326FOR Lasers

(Perry) Ultrashort Pulse Laser Deposition of Thin

Films. Application sent 10/11/99.

Applications in P	reparation:	
9928	NAI	(Ruggiero) Integrated Optical Capillary Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile
10209	Lasers	Parametric Wavelength Convertor (Sommargen) Application of the PSDI for
10334	Lasers	Measuring Convex Mirrors and Negative Lenses (Bajt) A Technique to Quantitatively Measure
		Magnetic Properties of Thin Structures at <10 nm Spatial Resolution
10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery with an Echo-Contrast Agent
10366	Lasers	(Banks) Method to Reduce Damage to Backing Plate using Prepulse
10391	Lasers	(Ishikawa) Gamma Watermarking

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE;

PCT Application Sent to DOE

UC Applications Submitted:

CIP Application

Continuation/Divisional Application:

Applications in Preparation:				
9928	NAI	(Ruggiero) Integrated Optical Capillary		
	•	Electrophoresis Chemical Microsensor		
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile		
		Parametric Wavelength Convertor		
10037	Lasers	(Frietas) Ruggedized, Microchannel-Cooled Laser		
•		Diode Array		
10209	Lasers	(Sommargen) Application of the PSDI for		
•		Measuring Convex Mirrors and Negative Lenses		
10334	Lasers	(Bajt) A Technique to Quantitatively Measure		
		Magnetic Properties of Thin Structures at <10 nm		
		Spatial Resolution		
10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery		
•		with an Echo-Contrast Agent		
10366	Lasers	(Banks) Method to Reduce Damage to Backing		
		Plate using Prepulse		
10391	Lasers	(Ishikawa) Gamma Watermarking		
10398	Lasers	(Rushford) Optical Monitor for Real Time Thickness		
		Change Measurements		

Advisor:

JOHN WOOLDRIDGE

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications Submitted:

10530 Lasers

(Sommargren) Inspection of Lithographic Mask

Blanks for Defects. Application sent PTO 12/07/99

Express Mail.

CIP Application

Continuation/Divisional Application:

10038B

(Small) Single-Fiber Multi-Color Pyrometry.

Divisonal sent PTO 12/16/99.

Applications in Pr	reparation:	
9928	NAI	(Ruggiero) Integrated Optical Capillary
		Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile
*		Parametric Wavelength Convertor
10037	Lasers	(Frietas) Ruggedized, Microchannel-Cooled Laser
		Diode Array
10209	Lasers	(Sommargen) Application of the PSDI for Measuring
•		Convex Mirrors and Negative Lenses
10334	Lasers	(Bajt) A Technique to Quantitatively Measure
		Magnetic Properties of Thin Structures at <10 nm
		Spatial Resolution
10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery with
		an Echo-Contrast Agent

DOE Applications Submitted:

CIP Application Sent to DOE:

Continuation/Divisional Application Sent to DOE:

PCT Application Sent to DOE

UC Applications	Submitted:	
10370	JPO/Lasers	Hand-Held Dental Imaging Device. Application sent
		PTO Express Mail 1/24/2000.
10443	Computations	Data Foundry Software. (from Dakin) Application
	/ BBRP	sent PTO express mail 1/7/2000.
10459	Lasers	(Hackel) Coherent Beam Combiner for a High
		Power Laser Application sent PTO 1/31/2000

CIP Application

Continuation/Divisional Application:

Applications in P	reparation:	
9928	NAI	(Ruggiero) Integrated Optical Capillary
	•	Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile
		Parametric Wavelength Convertor
10037	Lasers	(Frietas) Ruggedized, Microchannel-Cooled Laser
•		Diode Array
10209	Lasers	(Sommargen) Application of the PSDI for Measuring
	. •	Convex Mirrors and Negative Lenses
10334	Lasers	(Bajt) A Technique to Quantitatively Measure
		Magnetic Properties of Thin Structures at <10 nm
		Spatial Resolution

Monthly Report Worksheet - FEBRUARY 2000

9928	NAI	(Ruggiero) Integrated Optical Capillary Electrophoresis Chemical Microsensor
10028	Lasers	(Velsko) Compact, Flexible, Frequency Agile Parametric Wavelength Convertor
10037	Lasers	(Frietas) Ruggedized, Microchannel-Cooled Laser Diode Array
10209	Lasers	(Sommargen) Application of the PSDI for Measuring Convex Mirrors and Negative Lenses
10318	JPA/Eng	(Haddad) Method of for Transmission-mode Ultrasonic
10319	JPA/Eng	(Haddad) Method for Reflection-mode Ultrasonic Tomography
10321	JPO/ Engineering	(Haddad) Ultrasonic Breast Imaging System
10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery with an Echo-Contrast Agent
10366	Lasers	(Banks) Method to Reduce Damage to Backing Plate using Prepulse
10395	Lasers	(Chapman) Condenser for Ring-Field Deep- Ultraviolet and Extreme Ultraviolet Lithography. DG sent request to Dergosits & Noah (9/9/99) to prepare Continuation application
10398	Lasers	(Rushford) Optical Monitor for Real Time Thickness Change Measurements
10407	D&NT/ Lasers	(Perry) Ultra-Short Pulse Laser Machining System Employing a Parametric Amplifier
10447	Lasers	(Ishikawa) Composition Analysis by Scanning Femtosecond Laser Ultraprobing (CASFLU)
10483	Lasers	(Hackel) Ablation and Insulation Layer for Laser Peening
10520	Lasers	(Wilcox) Antiguided Fiber Ribbon Laser
10541	Lasers	(Zapata) Method for Optical Pumping of Thin Laser Media at High Average Power
10558 CR	Lasers	(Hackel) Contour Forming of Metals by Means of Laser Peening

Prosecution Sent to DOE or PTO:

9044	(Jones/Post) Appeal Brief with Petition to Reviveresp due
	12/7/99 Appeal Bried sent with 4 month extension 3/8/2000.
9967	(Goerz) Notice of Allowance, Notice of Allowabilityresp due
	4/12/2000. Issue Fee and Drawings sent PTO 2/2/2000
10095CPA	(Visuri) Notice of Allowance, Notice of Allowabilityresp due
	3/6/99. Issue Fee and Drawings sent PTO 2/8/00.
10122	(Everett) First Office Actionresp due 12/25/99 w/ 1 month
	extension. (from Daryl) Response sent PTO with 3 month
	extension 2/25/2000



UC Applications Submitted:

10334 Lasers (Bajt) A Technique to Quantitatively Measure

Magnetic Properties of Thin Structures at <10 nm Spatial Resolution. Application sent PTO express

mail 3/1/2000.

10472 Physics (Wittenau) Correlated Histogram Representation of

Monte Carlo Derived Medical Accelerator Photon-Output Phase Space. 9/30/99: Application sent

PTO 3/7/2000

CIP Application

10667 (Chapman) Condenser for Ring-Field Deep-

Ultraviolet and Extreme-Ultraviolet Lithography. This was IL-10395B. Application sent PTO

3/14/2000.

Continuation/Divisional Application:

PCT Application

10472FOR Physics IPAC has notified us to proceed with the Provisional

PCT Request. Request sent PTO 3/8/2000

Applications in Preparation: (Ruggiero) Integrated Optical Capillary NAI 9928 Electrophoresis Chemical Microsensor (Velsko) Compact, Flexible, Frequency Agile 10028 Lasers Parametric Wavelength Convertor (Frietas) Ruggedized, Microchannel-Cooled Laser 10037 Lasers Diode Array (Sommargen) Application of the PSDI for Measuring 10209 Lasers Convex Mirrors and Negative Lenses (Haddad) Method of for Transmission-mode 10318 JPA/Eng Ultrasonic (Haddad) Method for Reflection-mode Ultrasonic 10319 JPA/Eng Tomography JPO/ (Haddad) Ultrasonic Breast Imaging System 10321 Engineering (Visuri) Photoacoustic Enhanced Drug Delivery with 10344 JPO/Lasers an Echo-Contrast Agent

UC Applications Submitted:

10366 Lasers

(Banks) Method to Reduce Damage to Backing

Plate using Prepulse

CIP Application

Continuation/Divisional Application:

PCT Application

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Applications in P	<u>reparation:</u> 9928	NAI	(Ruggiero) Integrated Optical Capillary
		1	Electrophoresis Chemical Microsensor (Velsko) Compact, Flexible, Frequency Agile
	10028	Lasers	Parametric Wavelength Convertor
	10037	Lasers	(Frietas) Ruggedized, Microchannel-Cooled Laser
	10209	Lasers	(Sommargen) Application of the PSDI for Measuring Convex Mirrors and Negative Lenses
*	10318	JPA/Eng	(Haddad) Method of for Transmission-mode
	10344	JPO/Lasers	(Visuri) Photoacoustic Enhanced Drug Delivery with an Echo-Contrast Agent
	10398	Lasers	(Rushford) Optical Monitor for Real Time Thickness Change Measurements
	10407	D&NT/ Lasers	(Perry) Ultra-Short Pulse Laser Machining System Employing a Parametric Amplifier
	10447	Lasers	(Ishikawa) Composition Analysis by Scanning Femtosecond Laser Ultraprobing (CASFLU)
	10483	Lasers	(Hackel) Ablation and Insulation Layer for Laser Peening
	10520	Lasers	(Wilcox) Antiquided Fiber Ribbon Laser
	10541	Lasers	(Zapata) Method for Optical Pumping of Thin Laser Media at High Average Power
•	10558 CR	Lasers	(Hackel) Contour Forming of Metals by Means of Laser Peening

Prosecution Sent to DOE or PTO:

Advisor: EDDIE SCOTT

UC Applications Submitted:

CIP Application

Continuation/CIP/Divisional Application:

PCT Application

Applications in P	reparation:	10 11 10 11 nm
9928	NAI	(Ruggiero) Integrated Optical Capillary
00		Electrophoresis Chemical Microsensor
10387	Physics	(Wolfe) Reflective for Radiation Protection During
10007	1 1., 0.00	Processing
10490	JPO/Lasers	(Brown) Method for Creating Chemical Sensors
10430	Ģ. G	Using Microjet Technology. Provision sent PTO
		Express Mail 1/20/2000.
10507	Lasers	(Honea) Optical Coatings for Parasitic Suppression
10507		with Near Unity Low Angle Reflectivity
40000	Lasers	(Aulf) High Average Power Laser using a
10639	Lasers	Transverse Flowing Liquid Host
10011	Lasers	(Aulf) Device for Wavefront Correction in an Ultra
10641	Lasers	High Power Laser
	•	HIGH FOWER LASON

Prosecution Sent to DOE or PTO:

Pending Prosecution: 08/03/2000 9950

First Office Action—resp. due 8/3/2000. Was Daryl's.

Misc. Projects:

Eddie Scott

June 2000

Monday	Tuesday	Wednesday	Thursday	Friday
			1	2
5	6 IPAC Patent Reviews 9:00 am BBRP 10:00 am NAI 12:30 lunch Jim Skorich 2:30 prepare for Pratt/Whitney mtg 3:35 DMV appt	7 PAC Patent Reviews 9:45 am Environmental 10:00 am Energy 1:30 Tony Ruggiero (here)	8 IPAC Patent Reviews 10:00 am Lasers 11:00 am Lab Site Operations 12:00 Noon Chili Cook Off 1:15 Physics 1:30 Engineering	9 Time Cards 9:00 Paul Wickboldt 10:00 Tulk All Hands Mtg @ conf. rm
12	13	14	15	16 Time Cards
2:00 pm Amal Mtg @Here	10: am Bruce Tarter Announcement 2:00 EUV Lab TV	10:30 am Tulk staff mtg		
19	20 Time Cards	21	22	23
		Eddie on VACATION	Eddie on VACATION	Eddie on VACATION
4:00 Mtg Off Site			4:00 pm Patent Celebration West Cafeteria	
26	27	28	29	30 Time Cards
Mosting Off Site	10:30 Patent Priority mtg @ here	10:30 am Jan's Staff Meeting 1:15 pm Rod Balhorn		Joe Carrere After
Meeting Off Site 4:30 pm		· · · · · · · · · · · · · · · · · · ·	5:30 pm Evalina	5:00 pm

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	Saturday		8	15	22	29	
	Friday		7 12:00 PM Director's Office Purty	14 8:00 AM Time cards	21 8:00 AM Time cards	28 8:00 AM Time cards	*
	Thursday		6 9:30 PM Holzrichter 3:00 PM IPAC Linda Lerner	13 10:00 AM IPAC Reviews 10:00-moun: Lasers, Physics, LSO	20 5:30 PM Bvelina at 5:30	27 10:00 AM mg off site Richard Otter UC Merced 11:30 AM BBQ	
July 2000	Wednesday		5	12 8:30 AM IPAC Reviews 8:30-noon: Chem, Environ, D&NT, Energy, Engineering 10:30 AM Tulk Staff Mtg @ conf rm	4:30 PM Mtg. off site Tom Patternon	26 10:30 AM Tulk Slaff Mtg @ coaf fttt	-au-
	Tuesday		4 4th of July 5	9:15 AM IPAC Reviews 9:15-noon: NAI & IPO 10:30 AM Patent Priority mg 1:30 PM IPAC Reviews 1:30-3:00: Comp & BBRP	18	25 10:30 AM Patent Priority Mtg	
	Monday		3	10	17	24 8:30 AM Security (B274 Rm 1014)	31
	Sunday		2	6	16	23	30

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Saturday	5	12	19	26 11:00 AM Dr. Braker	
Friday	8:00 AM Time cards	11 8:00 AM Time cards	18 8:00 AM Time carets	25 8:00 AM Time cards 11:00 AM Dr. Appointment Dr. Braker	
Thursday	3 8:00 AM Stanford Medical Center	10	17	24 1:30 PM Meeting with Billy Colston ® My Office	31 11:30 AM Lanch with Jim
Wednesday	2 8:00 AM Stanford Medical Center	9 8:15 AM Move Into New Office	16	23 10:30 AM Tulk Staff Mag @ cond rm	3:15 PM Evelina at 5:00 pm 4:00 PM carpets will be clemed on Wechesday, August 30. They plan on starting at 4:00 p.m.
Tuesday	8:00 AM Stratford Medical Center	8:00 AM New Office Being Outfined - Work Out of Conference Room	7:30 AM Hacienda Motors	22 10:30 AM Planes Priority Mig 3:00 PM Meeting with Amemarie @ My office	29
Monday		7 12:00 PM Pack Office for Move	14 5:00 PM Hasienda Motors Tomotrow	21	28
Sunday		9	13	20	27

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Saturday	Saturday			91	23	30
Tridox	Friday	1 8:00 AM Time cards	8:00 AM Time cards 1:00 PM Bye Doctor Apppointment - Dr. Leong, Wahmt Creek	1.5 8:00 AM MRI 'Lasen' Workshop 10:20 AM Laboratory Counsel's Office Picnic	8:00 AM Time cards 9:00 AM Meeting with Ray Beach · IL 10507 · Optical Coatings for Parasitic Suppression @ EBS Office 11:10 AM Meeting with Courtney Davidson · IL 10217 System and Method for Chromatography @ EBS Office 4:00 PM LEON PANEITA Lecture	98
Thursday	I nursday	8	2:00 PM Klaus Kirschner, European Paran Anoncy Visit 4:00 PM carpets will be cleaned. They L plan on starting at 4:00 p.m.	1.30 PM MRI "Lasers" Workshop P	2 1 9-00 AM Mecting with Paul Wickholt II. (1937 - Reflective Coating for Radiation Protection @ EES Office 10:00 AM Presentation: patent drafting by Bud @ room 1034	29 3:00 PM Dr. Appoinment at 3:30 PM in 8:00 AM Time cards Walmu Creek Walmu Creek
Wodannedow	wednesday		9	13	20 8:00 AM Biotochnology & Software Patent Seminar - Millerse	27 10:00 AM Jan Tulk State of the Lab Presentation @ Rm 1034
	Tuesday		2	12	9:15 AM Bob Naismith 11:45 AM University of Glasgow	26 10:30 AM Patent Priority Mtg
	Monday		4 Labor Day		1830 AM Telephone Conversation with 9 John Hobrischter	26 8:00 AM Dr. Appointment at 8:00 AM in 10:30 AM Patent Priority Mtg Denville
	Sunday		3	10	17	24

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	Saturday	7	14	21	28	
	Friday	8:00 AM Time cards	8:00 AM Vacation Day	3A.3.	8:00 AM VACATION - Vistors from Houston	3
	Thursday	5	12 8:00 AM Time carits 11:30 AM Dr. Appointment (Endo)	19	26 8:00 AM VACATION - Vistors from Houston	
	Wednesday	49:30 AM Denial Appointment in Danville at 10:00 AM Sue Kone @ Danville 10:30 AM Tulk Staff Mtg @ conf rm 2:30 PM Tony Ruggerio @ EES Office	1	18	25 10:00 AM Time cards 12:00 PM Dr. Appointment (Wahut Creek @ 12:45)	ļ
5	Tuesday	3	10 8:00 AM German Auto Care	17	24 10:30 AM Parent Priority Mtg	31
	Monday	2	6	16	8:00 AM CLB - Conflicts of Interest TAPE 22B 9:00 AM CLB - Conflicts of Interest 10:00 AM CLB - Law Office Computer 10:00 AM CLB - Law Office Computer 11:15 AM 11:15 AM 12:00 PM CLB - Selected Problems in Ethics TAPE 25A 5:00 PM Milion & Paggy McGinty from	
	Sunday		∞	15	22	29

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Saturday	,		·			
	4	-		18	25	
Friday	8:00 AM Dentist Appointment 2:15 PM Time cards	10 8:00 AM Time cards 10:00 AM Aliphcon and WSGR visitors		7:30 AM Hacienda Motors 10:00 AM Meeting Bill Bernett @ Trailer 1527 conference room 12:30 PM Time cards 1:30 PM Tow Ruggerio 1:30 pm for a meeting on IL-99287	24 Thanksgiving 25	*
Thursday	2 7:30 AM Breakfast at Poppy Ridge with DOB Attorneys 8:30-9:30 am @ Poppy Ridge 8:30 AM DOB attorneys @ Poppy Ridge	9 7:30 AM Meeting with Miles Numermacher		16	Thanksgiving	30
Wednesday	2:00 PM Tult Staff Mig @ conf rm	8 5:00 PM Evalina at 5:30		15 10:30 AM Tulk Staff Mg @ conf rm 2:00 PM Duncon Maitland @ Here	22	29 10:30 AM Tulk Staff Mtg @ conf rm
Tuesday		7 8:00 AM VOTE 9:00 AM IPAC Meeting - Engineering 10:00 AM IPAC Meeting - DoNT		14	21 3:30 PM Time cards 4:00 PM Time cards	
Monday		9		1.30 PM Applied Energy Technologies and Health and Ecological Assessment 1:30 to 3 pm. @ in the Bldg. 123 anditorium.	20	27 1:30 PM Geophysics and Global Security 10:30 AM Parent Priority Mtg Division and Fasion Energy and Systems 12:00 PM Offsite Meeting - 11:30 am Safety Program @ Bid 123
Sunday		5		12	19	26

December 2000

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rday						
Saturday	2	6	16	23	30	
Friday	8:00 AM Time cards 12:00 PM Ladies Lunch	8:00 AM Time cards 9:00 AM Time cards 9:00 AM Carpet installation 11:00 AM DOE Intellectual Property Law Lunch @ The Brass Door	15 8:00 AM Time cards 9:00 AM Lab Counsel's Office Holiday Open House	22 8:00 AM Time cards	29 8:00 AM Time cards	
Thursday		9:45 AM pack up office 1:00 PM IPAC Holday Open House 1:00-3:00 @ T6925 Conference Room 3:15 PM Off Site Meeting at 4:30	10-00 AM Meeting Dime 10-00 AM Meeting Dime 2-30 PM Thomas Karl - Changes in Climate © Bilog 123 4-30 PM Bring Desert for Tomonrow's Open House	21 10:30 AM Mtg with Derek Deker - II. 10492 11:30 AM Meeting Offsite 2:00 PM Meeting Benert, Koopman, & Jim Richards at 2pm in T1527	58	
Wednesday		9	13 12:00 PM Lab Site Operations Open House @ BSS1 R2400	20 11.45 AM Lab Counsel's Office Holiday Luncheon	27 8:00 AM Check Holzrichter Put & AppMovecen	
Tuesday			12 10:00 AM Rod Balborn & Am Lee		Christmas	The second secon
		2	12 10:00 AM	19	26	
Monday		4 1:30 PM Yucca Mountain Program and Geosciences and Environmental Technology @ Bid 123	7:00 AM Carpet Installation 9:00 AM Director's Office Open House 3:00 PM Meeting Al Thompson & John Holzrichter	18 12:30 PM Amospheric Sciences Division and ARAC Programs and Tour @ Bldg 113 2:00 PM kiek off mag "institutional tumorials/workshops" @ B6925 R1110	25 Criterias	
Sunday		3	10	17	24	31

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	Saturday					
		9	13	20	27	
	Friday		12 10:00 AM Time cards	19 10:00 AM Time cards	26 10:00 AM Time cards	
	Thursday	8:00 AM Check Mail Box Expires Today 10:00 AM Time cards	11	3.30 PM Meeting Off-Site	2.50 PM Bert Weis, Patent Priority Moeting © Patent Coaf. Rus	
•	Wednesday	1	10 10-30 AM Staff Meeting 12-00 PM Patent Amorney Lunch	17 2:30 PM Michael Meltzer II. 10598 @ 5475 Room 1225	24	31
	Tuesday	2 New Year's Day 3	6	16	23 10:15 AM Al Thompson, Staff Meeting	30
	Monday 7	1 New Year's Day 2	S 10:00 AM Meeting at Ray Marellia's Office (Includes Don Lambert)	15 8:00 AM HOLIDAY	22	29
	Sunday		7	14	21	28

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February	

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	Saturday	3	10	17	24	
	Friday	2 9:00 AM Meeting with Collin Lan 3:00 PM Time cards 5:00 PM Appointment with Evalina at 5:30	9 10:00 AM Time cards 3:30 PM Bob Kuckuck's Retirement Reception @ West Cafe	16 10:00 AM Time cards	23 10:00 AM Time cards 5:30 PM Evalens @ 5:30	*
	Thursday	 1	S 9:00 AM Henry Enos at 9:00 am @ My Office 3:30 PM Ramer of U of Wesh Biomaterials That Heal 3:30 pm Thursday, Feb. 8 @ Bldg 123 anditorium	15	10:30 AM Future Security in a Technology Rich World" by T.J. Gilmartin @ Bldg. 1325, room 1784	
•	Wednesday		7 2:00 PM Staff Meeting	14	21	28 8:00 AM Kathy Raymond - Vacation Day
	Tuesday		9	13	20	27 10:30 AM Pazeni Priority Mtg Bert Weis
	Monday		S:00 AM Check Post Office Box - Expired 2/4/0.1	12	19 8:00 AM President's Day HOLDDAY 9:00 AM HOLDDAY	26
	Sunday		4		18	25

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Saturday	8	10	17	24	31
Friday	2 10:00 AM Time cards 4:00 PM Appt to take car in Monday	9 10:00 AM Time cards	16.00 AM Time cards	23 10:00 AM Time cards	30 10:00 AM Time cards
Thursday	1:30 PM Staff Meeting © here	8 3:30 PM Ron Frank re: IL-10540 @ Patent Conf. Rm	15	22	29 8:30 AM sick 5:30 PM Personal - 5:30 PM in Danville
Wednesday		7	14 10:30 AM Rod & Am at 10:30 am @ Conf. Rm Here 5:30 PM Appt. Evalena	21	28
Tuesday		9	13	20 9:30 AM Morrison & Focrster FESTO Briefing @ Palo Alto	27 10:30 AM Pazent Priority Moeting
Monday		7:30 AM Appt. Mercodes Benz Plesanton @ 7:30 am	12 3:30 PM Deep Sea Chemical Experiments - Peter Brewer @ Bldg, 123	19 10:15 AM Business Tutorial @ T-6928 couf. m. 11:45 AM Meeting Off Site	26
Sunday		4	11	18	

Eddie Scott - printed Monday, April 30, 2001 8:46 AM

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Saturday	7	41	21	28	
Friday	6 10:00 AM Time cards	13 10:00 AM Time cards 12:00 PM Appt. in Pleasanna at 12:15 5:00 PM Appointment after work 6:00 PM Reminder - Security Briefing Theesday at 8:15 am	20 7:30 AM Drop Off Car at Mercodez Bens of Pressistion 10:00 AM Time cards	27 8:00 AM Time cards	*
Thursday	2.00 PM IPAC Physics and Applied Technologies (Laser) 2.30 PM Staff Meeting	12	3:00 PM Appointment Offsite 5:00 PM Society of California Plotteers New Members 5:30 PM Tomorrow Drop Off Car at Mercelez Benz of Pleasanton	26	
Wednesday	4	1 1 2.00 PM Meeting with Gary Johnson & Tony Ruggiero	18 10:30 AM Staff Meeting	25	1
Tuesday	3	10	8:15 AM Bld. 274, Security Briefing. © Bld 274, Room 1020 Large Conference. Room	24 10:30 AM Parent Priority Mtg Bert Weis 10:30 AM Parent Priority Meeting	
Monday	2 3	9.30 PM Personal Appointment at 5:30	8:00 AM Spring Holiday HOLIDAY 8:00 AM Spring Holiday HOLIDAY BI 12:00 PM Spring Holiday HOLIDAY R	23 12:00 PM Sceretory's Day Lunch W	30 2.30 PM "Adaptive Optics: A 30-Year Personal Perspective" by David L. Fried Information Science & Technology Program, takes place in Bidg. 219, room 163 @ Bidg. 219, room 163
Sunday	10.30 AM U of W President's Brunch	∞	15	22	29

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Sunday	Monday	Tuesday	Wednesday	Thursday	Friday	Saturday
		28:30 AM CCTT meeting @ Bidg. 123 Conf. Rm	28:30 AM At Sc[i]3 Penerus and Trademarta - Sumayvate, CA 8:30 AM umil 12:00 Noon @ 465 S. Mathlida Ave., Sumayvate, CA 2:00 PM Staff Meeting	3 11:00 AM Meeting in Waltust Greek	4 10:00 AM Time cards 6:30 PM 6:30 Appointment	ν _γ
9	7	∞	3.45 PM Bagene Spafford, professor of computer sciences and philosophy at Pardue University @ Bidg. 543 auditorium	10 10.00 AM Camer for Global Scennity Research "Developments in Russian Nuchear Policy" by Nikolal Sokov, @ Bidg. 132, South CGSR conference room 1781	1 1 9:00 AM Jm and Patent Attys	12
13	14 s:30 PM losef Bockhomi	8:30 AM Business Workshop Planning © T-6925, m. 1110	16 9:00 AM Meeting-Toni @ Library 1:00 PM Meeting Off-Site	17	18:15 AM Shiff Meeting 12:00 PM Time cards	19
20	21	22	23	24	25 10:00 AM Time cards	26
27.	28 8:00 AM Memorial Day HOLIDAY	29 10:00 AM Patent Priority Meeting @ Patent Conference Room	30	31		

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Saturday	2	6	16	23 11:30 AM Society of Cal Pioneers 11:30 - 2:30 @ Memio College	30
Friday	10:00 AM Suff Meeting 4:00 PM Time cards	8 10:00 AM Time cards	15	22 8:00 am Vacation day	29 8:15 AM ON TRAVEL - Albuquerque 12:45 PM ON TRAVEL - Return to California
Thursday		7 8:00 AM TECHNOLOGY PARTNERUNG 2001 - Argome Lab 5:15 PM Return to So. Gate	14 9:00 AM 18y Ayer at 9:00 AM @ Bidg 2775, Room 1009 (West Wing)	21 10-00 AM TID OPEN HOUSE June 21 from 10 to 3. @ in Building 551 W 3:15 PM Time cards	8:15 AM ON TRAVEL - Los Alimos
Wednesday		6 8:00 AM TECHNOLOGY PARTNERING 2001 - Argouise Lab @ Chicago	13	20	8:00 AM ON TRAVEL - Travel to Los Alamos
Tuesday		So. Gate 12-45 PM TFAVEL. 3-45 PM TFWG Meeting, Chicago	12 10:00 AM Jim Holst and John Lundberg of the Genstal Counsel's Office at the University of California @ TSG77, R 1034 3:00 PM Bala Swamy Interview @ T-6925, conf. m	5:30 PM Appointment with Derren	26 8:00 AM Vacation Day
Monday		4	8:00 AM hartwi@smdit.gov> You are on. Let me know when you are free. 2:00 PM Center for Global Security Amy Myers @ Bidg. 1325, Room 1781	18	25 8:00 AM Time cards
Sunday	×	8	10	17	24

ATTACHMENT A

LAWRENCE LIVERMORE NATIONAL LABORATORY P.O. Box 808, Livermore, California 94550

LLNL File No.

MAR 2 3 1995 P.O. Box 808, Livermore, Californi	a 94550		IL-	9928
LINL PATENT GROUP This invention was made in the course of or under prime Contract No. W-7405-ENG-48 between the U.S. Department of Energy and the University of California. This Disclosure and Record of Invention is presented to the				
Office of the Assistant General Counsel for I. <u>Title of Invention:</u> Integrated Optical Capillary Electrophoresis Chemical Microse	or Patents, U.S. De	epartment of Er ayroll Account N	nergy.	1
II Investor (A) (See A. AS I II . ()	98		ivision / NAI	
Australia	Employer	Phone No.	Fax No.	Mail Stop
Anthony , J., Ruggierre Physical Chemist LLNL	3	3-1020 2-	-4544	<u>L-183</u>
JUN 2 4 2004 20			· · · · · · · · · · · · · · · · · · ·	
This invention is a paintable chemical micro-sensor module the is constructed using a unique combination of integrated optic chemical analysis instrument on a chip, this sensor will set using capillary electrophoresis (CE) and a novel universal based on two beam interferometry using integrated optical interferometer geometry. It can be configured to detect chemical either direct refractive index (RI) changes due to the analyte absorption. The latter changes can be either photo-thermal between ground and excited states of the analyte. Designed requirement, this device will be suitable for use as an open sensor on a wide variety of platforms (e.g., on UAV's or IV. List past uses, current uses and potential uses for your investigation.	parate and planar c parate and identification optical detection wave guide struct mical species sepa e, or photo-induction in nature or resul- for minimum size trator controlled fin in unattended gro	y components system. The tures in a Macl arated by CE led RI changes it from polarizate and a low pro-	rication tech s of comple detection sy h-Zehnder by measure resulting fr ability differ rime power	hniques. A ex mixtures ystem is ement of rom analyte erences
Rapid, automated trace chemical analysis and in-situ identification of aqueous effluents, extracts or condensates associated with the development, production or handling of weapons of mass destruction (WMD). Battlefield detection of biological and chemical warfare agents				
Commercial, or other uses or possibilities for use:				
Applications of this technology include environmental monitoring, forensics science, pharmacological and medical sample analysis and industrial chemical process monitoring.				
V. <u>Documents</u> , <u>publications</u> and <u>presentations</u> , <u>describing</u> the invention, that you have <u>published</u> or <u>prepared for</u> <u>publication</u> , or <u>presented on the subject</u> . Also, include <u>presentations</u> and <u>publications</u> planned within one year from now:				
<u>Title/Subject</u> Ultrasensitive Compact Integrated Optic Sensors for Trace Analysis of Complex Aqueous Mixtures, FY94 Advanced Concepts Proposal and Pres.	<u>Dat</u>		<u>Publicati</u>	ion No.
Presentations to DOE NN-20 Officials atLLNL	11/17/94,4/12			
	<u>1/8/96, 2/26/9</u>			
Optoelectronic Sensors at LLNL, DOD Photonics Conference	3/26/96	70		
Mclean VA.	_ 3/20/30			
	- Only Societa		 .	
All presentations and documents to date have been for Official Use Only See attached note VI. Related Documents, (Including patents, other publications): Please include: Patent No.'s, Authors, Title, Publication Date, etc.				

ENL File No.: 1L- 9938

VII. DESCRIPTION:

Background of the invention, including technical problems addressed by it:

See attached documents. Currently the primary limitation to the widespread use of capillary electrophoresis (CE) for trace field analysis is the lack of suitable low-sample volume (nanoliter-picoliter) optical detectors. Consequently, the high separation resolution delivered by CE is often lost at the detection stage. The most sensitive optical techniques currently in use are based on laser induced fluorescence and are limited to fluorescent molecules or molecules that can be easily derivitized with the appropriate fluorophore. This limitation often precludes the use of CE for ultrasensitive field deployable sensors. Work on universal CE detectors (detectors that respond to virtually all compounds) is currently a major topic of research. DOE NN-20 Advanced Concepts research in FY94 and FY95 explored the fundamental measurement physics, feasibility and general performance issues involved in the design of a novel all solid state field deployable ultra-sensitive universal CE detector/chemical sensor system . The device is based on two beam interferometry in compact fiber coupled integrated optic (IO) Mach-Zender waveguides. In this type of sensor, the optical phase of the light passing through the device is modulated by a change in absorption induced refractive index in the CE capillary caused by the chemical species to be detected. The phase modulation is then measured interferometrically by comparing the phase of the light in the CE sample arm to the reference arm. The key feature that separates this approach from other thermo-optical and interferometric based CE detection approaches is the use of close coupled CE/IO device architecture's. This sensor has a number of attractive features. Optical phase information is demodulated, by detection of all the light emerging from the interferometer rather than a spatially selected component or fringe. Consequently, the signal is independent of thermal lensing artifacts due to the spatial distribution of the excitation beam and is also much less sensitive to misalignment than conventional fringe shift techniques. The system is also well suited to both active and passive homodyne stabilization techniques that would be required for field deployment. Other advantages include, wide dynamic range, high sensitivity, low overall energy budget and the potential for device multiplexing for decreased analysis time and/or improved species identification. Recently, advances in CE miniaturization have resulted in the development of entire CE systems including electrokinetic sample injectors on palm sized glass "chips". This type of planarized chip technology is ideal for interfacing with IOCE detection systems described above. As a result of the Joule heating accompanying electrophoresis, thermal management is a crucial parameter in determining both efficiency and resolution in CE separations. At LLNL, we have developed and tested a micro-fabrication strategy for electrokinetically injected planarized CE systems on advanced ceramic substrates. Average size of some of the prototype devices allows them to be placed on top of a US quarter. Choice of CE chip substrate material used in microfabrication provides a yet untapped parameter for CE system optimization. Thermal conductivity of the CE chip substrate can easily be increased one to two orders of magnitude over conventional fused silica and glass based systems. Specifically, the use of sapphire, diamond or CVD diamond would be optimal. With regard to an IOCE type detector /sensor system this should translate to increased system response time and decreased analysis time. New CE chip substrate materials also permit optimization of crucial solute/capillary wall interactions via choice of inherent substrate surface charge states.

Summary of the Invention (you may attach a paper). Please include a sketch of the invention, if possible:

See attached documents

LLNL File No.: _IL- 1928			0
	LLNL File	No.: IL-	9928

PROPRIETARY	INFORMATION-FOR INTER	INAL LINE RISE ONLY	
VIII. Inventor's Permanent Home Add	lress(es):		
<u>Name</u>	Citizenship Street A	Address City, State, and Zip Code	
Anthony J. Ruggiero	USA 1251 Murdell Lane		
			-
			-
Please attach a separate sheet for addition			
IX. Funding Source or Project Under DOE NN-20 Advanced Concepts	Which the Invention Arose: Plea	ase include subcontracts or special project informatio	n.
DOM 1111 EU / 101 EU / 100 EU / 100 EU	Program		-
Resource Manager: Jim Caselli		Di	_
	LIAU Assoupt No : E292 E0	Phone No.: 422-9055	-
DOE Program Code: ST043D	LLINL Account No.:_5382-50	Subcontract No.: (if applicable)	
Is funding presently being provided for	r development of your invention.		
Please state the source of funds: (if sa	ame as above, please so state)	165. <u>A</u>	
same as above			
Do you reasonably expect future fundir	ng from the current source or oth	er sources: Yes:_X No:	
If yes, what is that sourceUOE NN-2	Office of Research and Develo	ppment	
X. Conception (Date, Place): 7/10/93			
	onception Date	Conception Place	
Earliest documentation of your inve		entify the document)	
First Sketch or Drawing: 11/2 First Written Description: 11/2	2/93 2/93		
Names of witnesses or others	with knowledge of facts relating t	to conception:	
Full Name	Organization	Telephone Number	
Albert J. Ramponi David H. Dye	LLNL / J-Division/ NAI	423-3363	
	LLNL/ NAI	422-5036	
(I. Reduction to Practice:			<u> </u>
Date first model completed: July 1994			
Date of operation and testing: <u>July 1994</u> Place of test: LLNL	4		
Results of testing: <u>Demonstrated gene</u>	eral feasibility of detection conce	nt	
Vitnesses or others with direct knowled		<u>pt</u>	
<u>Full Name</u>	Organization	. <u>Telephone Number</u>	
Albert J. Ramponi Mike Stagos	LLNL J-Div/NAI	423-3363	
	LLNL ERD	422-3682	_
We) believe myself(ourselves) to be the	e first and original inventor(s) of	the above-described invention:	
WENTOR: () lly	Japan	_ DATE: 3/23/96	
ATNESS: A. Kapni /		DATE: 23 March 1996	
VENTOR:			
/itness:		_ DATE:	
IVENTOR:		·	ļ
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LLNL File	No.:IL	- 4928

Basis for unclassified release:	ELL FOR ALL UNCLASSIFIED DISCLOSURES
_X Outside scope of AEA and EO	
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CG-DAP-1, Topic(s) Other Guide(s)	
Topic(s)	
UCNI: _X NOYES, guide	
Authorized Derivative Classifier:	Confirming Reviewer:
Albert J. Ramponi	
Name	ren Moen
J-Division Group Leader	Name 3/26/96
Title	Signature
Signature	
FOR LUNL PATENT GR	OUP USE ONLY
Possible Statutory Bars:	
Publication:	
Public Use/Sale:	
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Recommended Filing Date Due to Possible Statutory Bars:	
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MA III	11/11/01
	4/4/96
LLNL PATENT ADVISOR	
	DATE

TC-9928

3/21/96

Regarding documents, publications and presentations, describing the invention, that you have published or prepared for publication, or presented on the subject. Also, include presentations and publications planned within one year from now:

All presentations, briefings and written documents to date involving this invention have been to DOE NN-20 sponsors or government agencies and were for official use only. The following publications/presentations are planned in the immediate future

Mark Lowry and Anthony Ruggiero, "Optoelectronic Sensors at LLNL" ,,DOD Photonics Conference. 3/26/96 Mclean VA ,

Anthony Ruggiero and Micheal Staggs, "Laser Beam Coupling to Micro-Capillary Tubes", in preparation for submission to Analytical Chem Lett. in late summer 1996.

Anthony Ruggiero and Micheal Staggs, "Universal CE Detection Using Two Beam Interferometry", in preparation for submission to Analytical Chemistry in late summer 1996.

Advanced Concepts Program complex mixtures —

Principal Investigator: Anthony J. Ruggiero



J-Division Lawrence Livermore National Laboratory

June 27, 1995

microsensor for trace analysis of aqueous mixtures We are developing a unique field deployable



- the sensor system incorporates:
- micro-analytical chemical separation via Capillary Electrophoresis
- "universal" detection by two beam interferometry using integrated optic technology
- target application: trace component analysis of waste water, condensates, and leachates associated with refining, processing and reprocessing of nuclear materials
- additional applications:
- analysis of CW and BW agents and associated chemicals
- pharmo-kinetic and metobolic sensors
- industrial chemical and biochemical process control monitoring
- environmental monitoring

Desired microsensor characteristics



- high detection sensitivity
- large dynamic range
- low sample volume requirements
- compact, lightweight, rugged, and reliable
- low energy budget (power consumption)
- rapid automated sample handling and real time analysis
- level of automation suitable for unattended operation or RPV

Integrated electro-optical components are well suited to sensor applications



- 10 components are the optical counterpart to integrated electronics
- light signals are controlled and manipulated electronically within miniaturized waveguides made on a common substrate
- waveguide structures confine, guide and provide a propogation path for the
- alignment and mechanical sensitivity issues are minimized
- low optical loss
- no moving parts involved in beam manipulation and modulation
- low drive voltage requirements
- compact and modular packaging
- multiple optical components can be combined on a single chip
- multiple sensor chips can be multiplexed

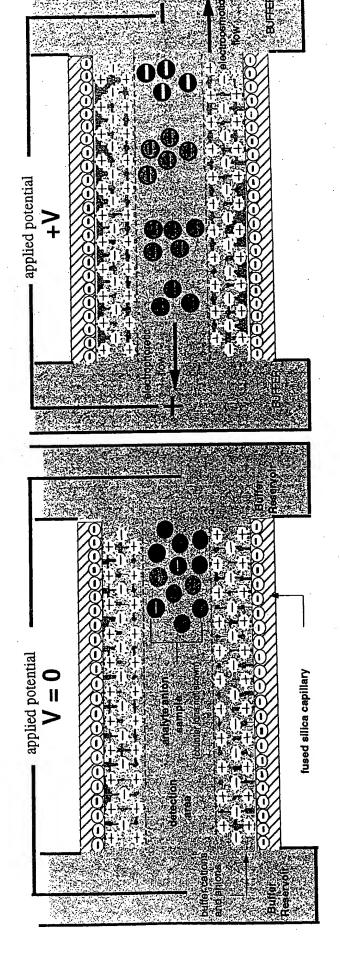
Capillary electrophoresis is a calibrated microanalytical chromatographic technique



In CE, sample ions in an applied field differentially migrate and are detected at characteristic transit times.

(1) t = 0, sample injected into capillary

(2) t = t1, sample component 1 detected



CE combines the strengths of both HPLC and conventional electrophoresis



- capable of operation in aqueous media (most forms of liquid chromotography require non-aqueous solvents)
- small sample volumes (nanoliters to picoliters)
- resolution is independent of column length
- ideal choice for trace analysis of
- inorganic ions, small organic molecules
- organic acids, water soluble polymers
- biomolecules (protiens, peptides, neorotransmitters, DNA etc.
- fabricated on silicon and glass and is currently an area of active research micro-machined CE systems with integrated sample injection have been

deployable sensors is limited by detection technology Widespread use of CE for trace analysis in field



- micro-analytical fluid phase techniques such as CE are an active area of suitable low sample volume (nanoliter to picoliter) optical detectors for research
- laser induced fluorescence is currently the most sensitive optical technique
- limited to fluorescent molecules with large quantum yields
- molecules that can be easily derivitized with the appropriate chromophore
- many naturally fluorescent chromophores are quenched in water

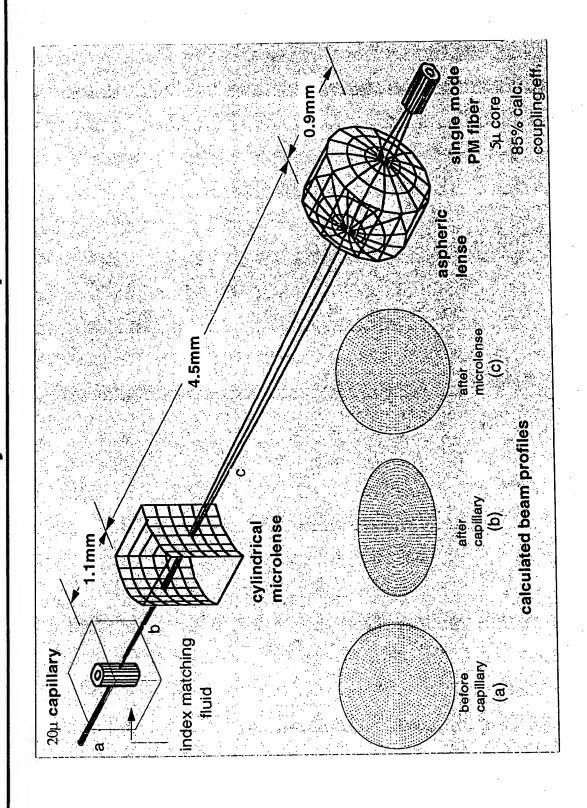
Combining CE and integrated optical interferometry offers several advantages for chemical sensing



- incorporation of a separation step in a sensor system dramatically reduces selectivity requirements
- electric field driven separation based techniques like CE are:
- rapid
- exhibit excellent resolution performance
- well suited to miniaturization, microsampling and automation
- optical phase shift measurements are extremely sensative and can be used as "universal" detectors
- well developed IO micro-fabrication techniques make possible
- increased on chip functionallity
- low power consumption and ease of packaging
- 10 components are already established as reliable, rugged and field proven
- temperature stable
- impact resistant

microlense to correct for systematic optical aberations Computer modeling was used to design a cylindrical





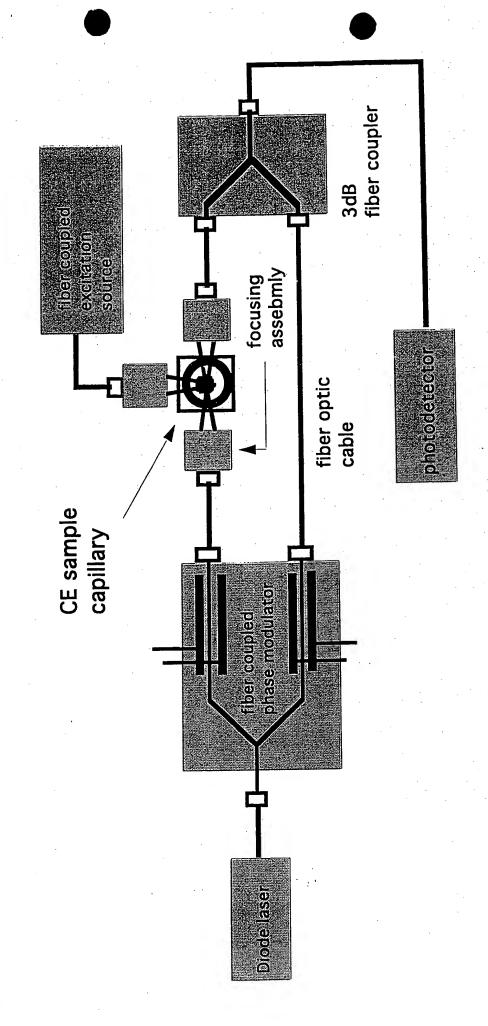
The IOCE sensor can be configured in two detection formats based on optical phase shift measurements



- direct refractive index (RI) measurements based on modulation techniques
- photoinduced RI measurements
- photo-thermal detection
- absorption by resonant optical excitation induces a refractive index change by local heating of the sample excitation volume
- the refractive index change is detected by the nonresonant MZ probe
- laser induced RI detection * (new technique under development)
- absorption by resonant optical excitation induces a refractive index change of the sample excitation volume via the excited state polarizability
- the refractive index change is detected by the nonresonant MZ probe

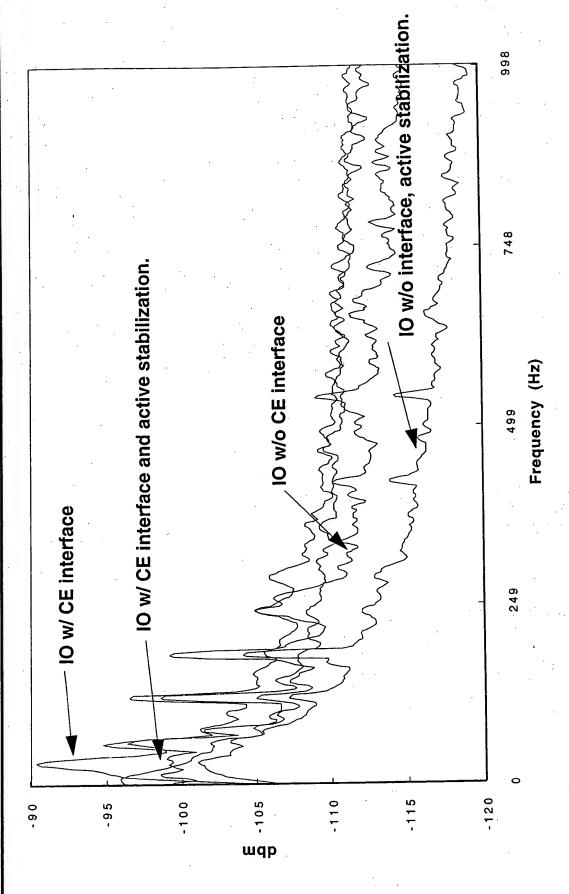
Schematic of discrete component IOCE prototype for Phase I feasibility studies





Spectral noise analysis of the Phase I discrete component system prototype



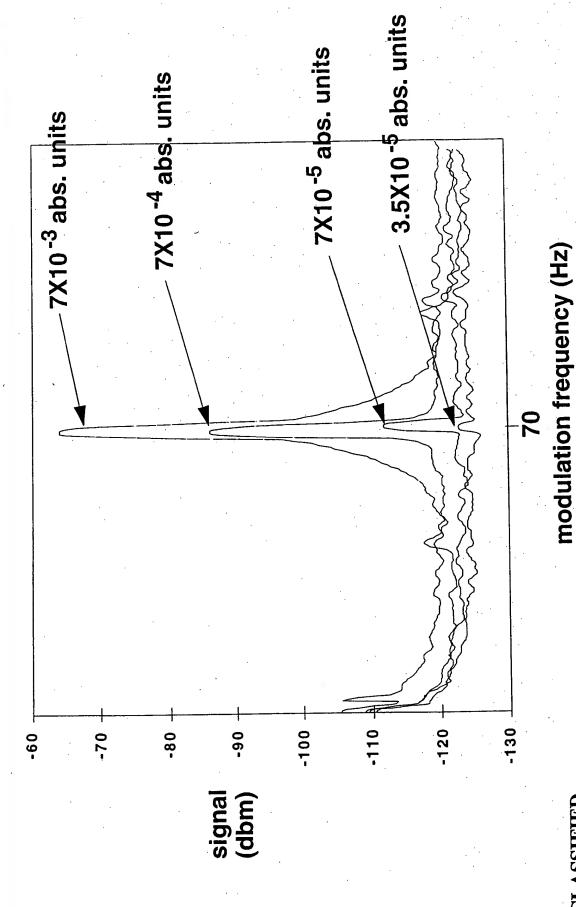


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AJR-PP#-10CE 118/9/9594-26

measurements made on fluorescene/water samples Signal spectra of thermo-optical absorbance





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AJR-PP#-IOCE 118/8/9594-24

Comparison with competing absorbance detection technologies* for a 20μ pathlength in abs. units

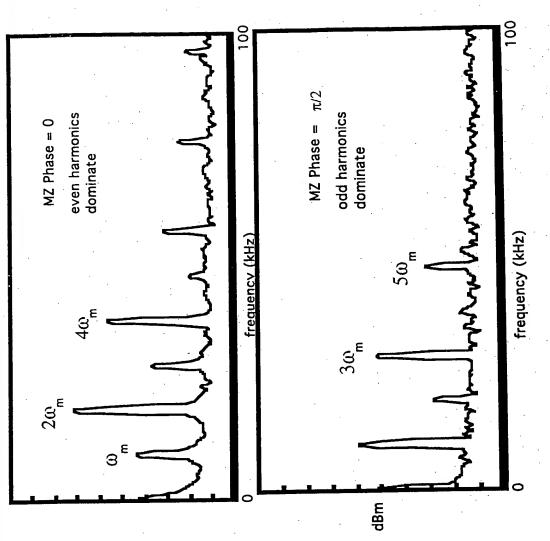


- universal detection approaches demonstrated in chromatographic applications include:
- direct absorption 5X10⁻²
- thermal lense detection 4X10-4
- Fabry-Perot RI detection 4X10⁻⁵
- laser intracavity absorption 5X10⁻⁵
- photoacoustic detection 1.2X10⁻⁵
- theoretical sensitiviy limit for the IOCE approach is calculated to be on the order of 5X10-8
- Absorbances in the 10-5 10-6 range have been detected with protoype **IOCE** devices in our laboratory
- many of the above techniques
- are not easily configured into miniature, rugged fieldable sensors
- general use is restricted by experimental complexity
- * adapted from E. Young, "Laser Spectroscopy for Detection in Chromatography" in Analytical Applications of Lasers

stabilization and improved S/N via phase modulation Both passive and active techniques are possible for



components can be generated that eliminate signal fading signals composed of both problems associated with in-phase and quadrature thermal and mechanical



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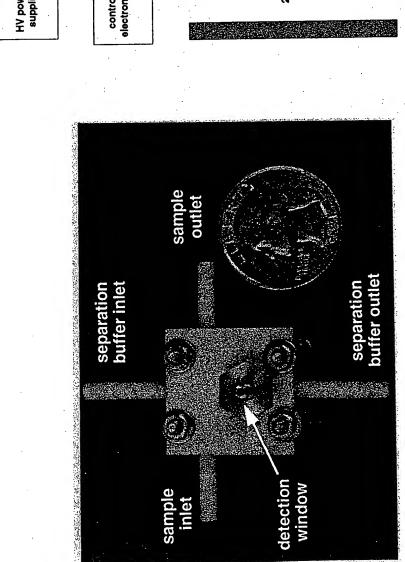
parameters in determining CE efficiency and resolution Thermal management and surface charge are crucial

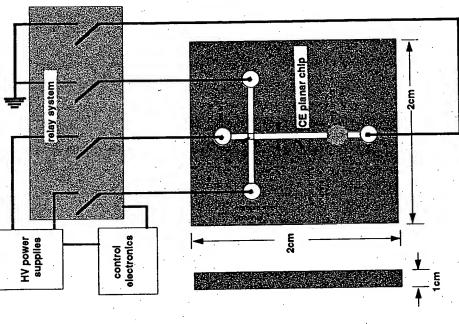


- Joule heating accompanying electrophoresis
- affects separation resolution
- analysis time by defining operating voltages
- surface charge effects separation efficiency through solute wall interactions
- the thermodynamics of the system also determins detection response time for thermo-optical based measurements

LLNL ceramic planar chip CE prototype with electrokinetic sample injection





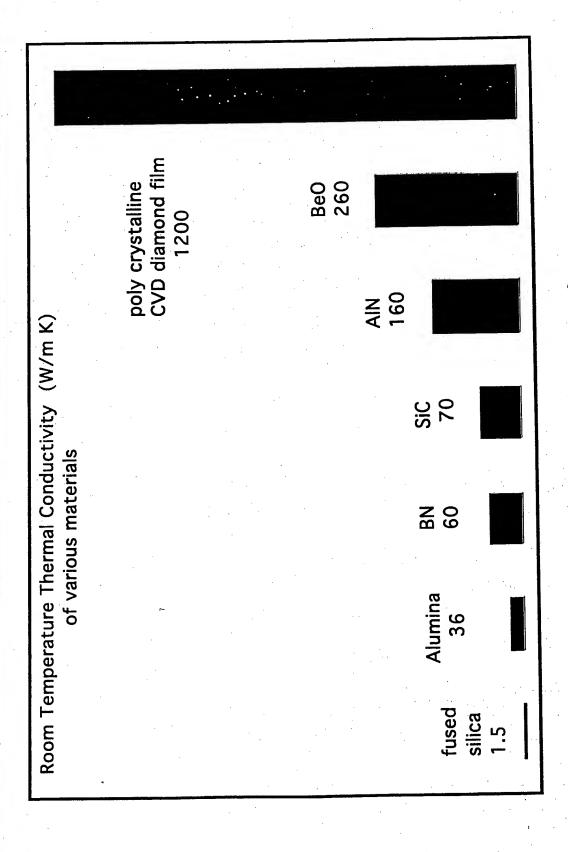


CE system schematic

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A.R. PP#-10CE 113/19/9694-27

Choice of CE chip substrate material provides a yet untapped parameter for CE system optimization





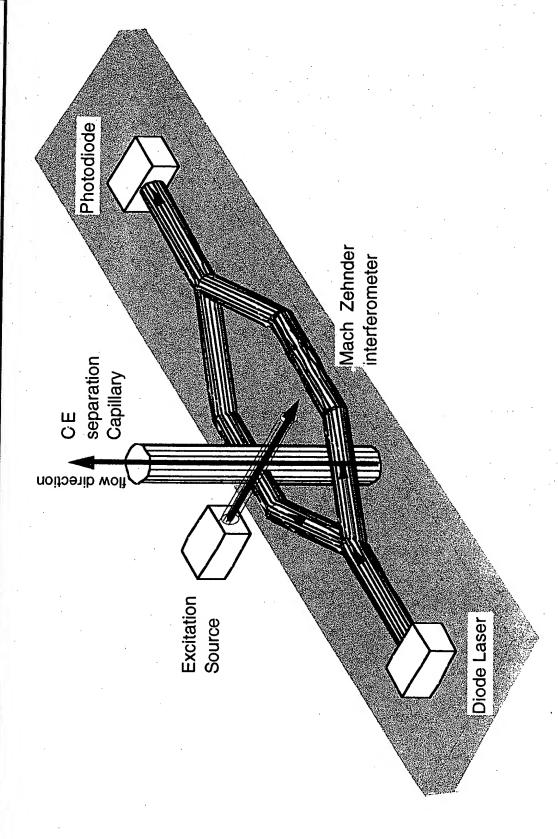
Summary



- a novel 10 based detection scheme suitable for a field deployable sensor has been conceptually developed and initial feasibility has been established
- induced at the IO/CE interface, verifying our ability to efficiently couple high quality laser beams from the CE capillary to the IO components microlense technology has been developed to correct for beam aberations
- a prototype IOCE device has been fabricated from discrete components and
- preliminary feasibility tests using active stabilization and phase modulation of the IOCE system have been accomplished
- final testing and evaluation of the Phase I demonstration prototype detection sensitivity is currently underway
- a micro-fabrication strategy for a electro-kinetically injected planarized CE system has been developed and tested
 - a phase II sensor prototype incorporating IO components with greater on chip functionality and a planar chip CE system has been designed and is under construction

Conceptual diagram of the integrated optic capillary electrophoresis (IOCE) chemical sensor module

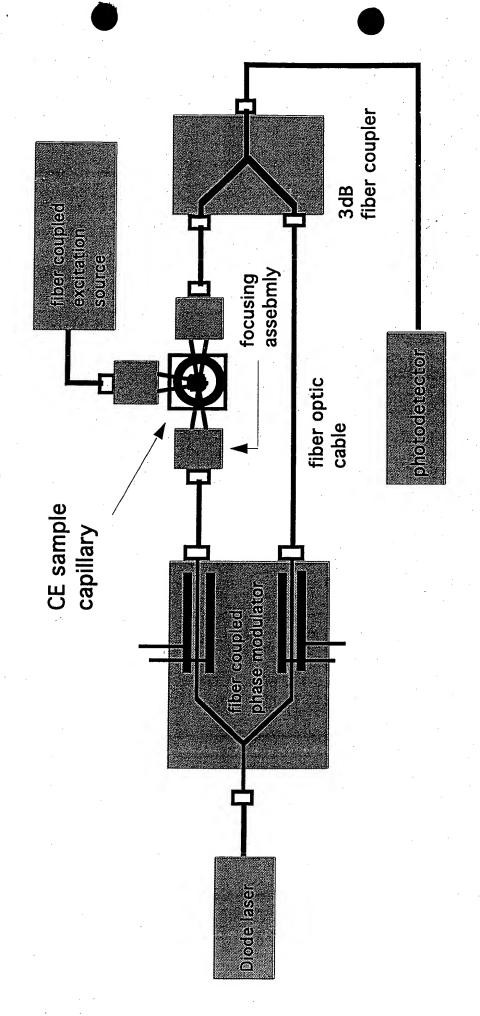




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Schematic of discrete component IOCE prototype for Phase I feasibility studies

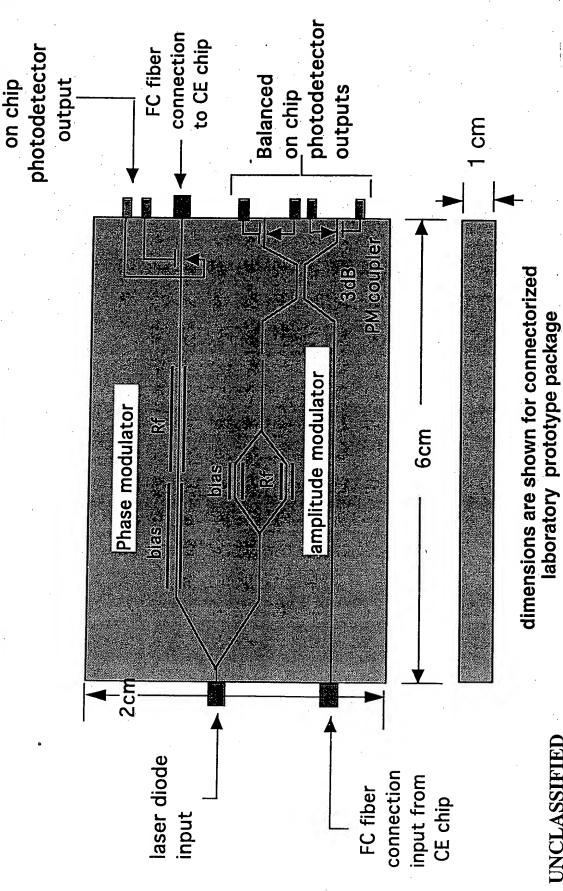




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Phase II prototype IO device schematic

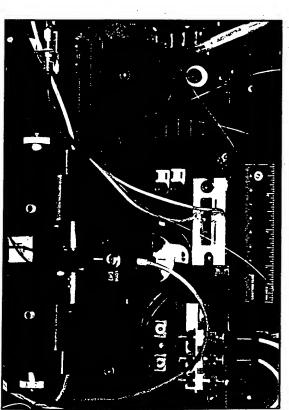




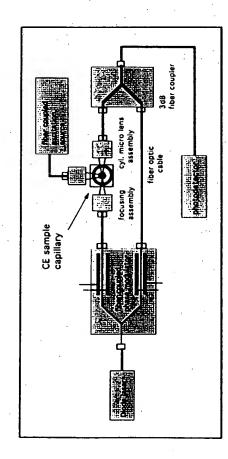
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AJR-PP#-10CE 118/9/9594-18

INTEGRATED OPTIC MICROSENSORS FOR TRACE **ANALYSIS OF COMPLEX AQUEOUS MIXTURES**



Phase 1 discrete component prototype



Schematic of discrete component IOCE prototype

DESCRIPTION:

- Chemical microsensor system employing capillary electrophoresis and unique integrated optic detection technology
- Compact, low energy budget, nanoliterpicoliter sample volumes
- Rapid automated microsampling and real-time analysis

APPLICATION:

- Trace component analysis of waste water, condensates, and leachates associated with refining, processing and reprocessing of nuclear material
- On-site inspections, unattended monitoring or use in remotely piloted vehicles

SPONSOR:

U.S. Department of Energy, NN-20

DEVELOPER:

Lawrence Livermore National Laboratory

INTEGRATED OPTIC CAPILLARY ELECTROPHORESIS MICROSENSOR FY97-FY99 LIFECYCLE PLAN PROPOSAL

PRINCIPAL INVESTIGATOR:

ANTHONY J. RUGGIERO

LLNL, J-DIV. APPLIED

TECHNOLOGY PROGRAM, NAI

CO-INVESTIGATOR:

FRANK PATTERSON

LLNL, PHY. DEP., PHOTONICS GROUP, PHYSICS AND SPACE

TECHNOLOGY

CO-INVESTIGATOR:

JIM FOLTA

LLNL, MICROTECHNOLOGY CENTER, ELECTRONICS ENGINEERING DIVISION

FUNDING

START DATE:

10/1/97

FUNDING COMPLETION DATE:

10/1/99

FUNDING

	<u>OF</u>	ERATING \$	CAPITAL \$
FY	1997	1480K	150K
FY	1998	1800K	50K
FY	1999	1200K	50K

PROJECT DESCRIPTION:

Based on the results of a recent NN-20 Advanced Concept project, a field deployable chemical microsensor module will be developed for rapid, automated trace analysis and in-situ identification of aqueous effluents, extracts or condensates associated with the development, production or handling of weapons of mass destruction (WMD). The palm size sensor module will have detection sensitivities in the sub-ppm range and will be constructed using a unique combination of integrated optical and planar chip microfabrication techniques. A chemical analysis instrument on a chip, this sensor will separate and identify components of complex mixtures using capillary electrophoresis and a novel universal optical detection system.

There are no requirements for volatile, thermally stable compounds or derivitives as in gas chromotography (GC). Aqueous samples containing complex chemical species with a wide polarity range can be analyzed in a single run directly from a crude field sample after a simple filtration. Unlike most forms of high performance liquid chromatography (HPLC) that share this advantage, however, large volumes of non-aqueous solvents are not required. Designed for minimum size and a low prime power requirement, this device will be suitable for use as an operator controlled field instrument or as an unattended sensor on a wide variety of platforms (e.g., on UAV's or in unattended ground sensor systems). It will represent the state of the art in fieldable chemical micro-analytical instrumentation.

PROJECT SUPPORTS:

Treaty on the Non-Proliferation of Nuclear Weapons, Chemical Weapons Convention

PROJECT STATEMENT OF WORK

Objective:

The primary project objective is to develop a compact fieldable micro-sensor module that can be used to rapidly isolate, identify, and quantify inorganic or organic cations and anions of interest in water samples, condensates, leachates, or aqueous atmospheric aerosol extracts. The module will be a compact, energy efficient device that can be easily incorporated into a variety of field platforms. It will include a versatile micro-fabricated pre-analysis sample preparation and injection manifold that will enable the system to be easily interfaced to user specified sample collection formats.

Application:

After calibration for the chemical species of interest, the field deployed system will detect and quantify radionuclides and chemical signatures in aqueous effluent samples obtained from facilities that are potentially indicative of weapons of mass destruction (WMD) proliferation activities. Dual use and spin-off applications of this technology include environmental monitoring, forensics science and, pharmacological and medical sample analysis.

Prior Work:

The proposed work is a continuation of a DOE NN-20 Advanced Concept project initiated in FY94 by the P.I. to investigate the feasibility of combining solid state laser and integrated optic (IO) component technology with micromachined planar chip capillary electrophoresis (CE) systems. Prior work emphasized fundamental physics of the IOCE interface and the detection technology, providing optical and thermo-mechanical design tolerances for the system.

Capillary electrophoresis (CE) has been regarded by many in recent years as a major breakthrough in fluid phase separation science. It is now an established and well understood microanalytical technique. CE combines the strengths of both high performance liquid chromatography (HPLC) and conventional electrophoresis to yield rapid, precise, automated, and highly efficient analysis of complex chemical mixtures using minimal injected sample volumes (picoliter-nanoliter, see Figure 1.). Most forms of high performance liquid chromatography require non-aqueous solvents, CE, however, is capable of operation in aqueous media, making it the ideal choice for trace analysis of inorganic ions, small organic molecules, organic acids, water soluble polymers and biomolecules (proteins, peptides, neorotransmitters, DNA etc.). Samples for analysis can be obtained directly in the fluid phase, or as extracts from solids or condensates. Analyte concentration on solid phase chemical or particle filters prior to aqueous extraction and analysis is also possible.

The rapid growth of this analytical technique is due to the inherent simplicity of the required hardware and the fact that the physics of the separation are easily controlled by the choice of electrolyte. In essence, the electrolyte and polarity of the applied voltage programs the capillary to separate anionic, cationic, or neutral species. This is in contrast to established ion analysis techniques, such as ion chromatography, where separations are wholly dependent on dedicated specialized analytical columns. High CE separation efficiencies result from the use of small separation channels or capillaries, 20-100 microns in diameter. Since the efficiency is independent of channel length, the entire approach is extremely amenable to micro-fabrication and miniaturization. In fact, CE performance improves with reduced size.

Chemical sensing systems based on capillary electrophoresis can be versatile, sensitive and selective. The detector can be optimized for sensitivity without regard to selectivity, while the electrophoresis separation capillary can be optimized to yield high selectivity toward a particular chemical species or class of chemicals. The system is versatile in the sense that the same system hardware can be used for analysis of a wide variety of different types of chemicals by manipulation of the CE separation conditions. This is in contrast to most chemical sensors in which a tradeoff exists between versatile

performance, sensitivity and selectivity.

CE based sensors, with their ability to directly analyze crude aqueous field samples, can offer tremendous advantages in the treaty verification and proliferation detection arenas. For example, identification of precursors and degradation products of chemical warfare agents must often be unambiguously identified from various matrices during the treaty verification process. The degradation (hydrolysis) products, alkyl-substituted organophoshorus acids, are polar, have low volatility and are easily isolated from various matrices by extraction with water. While easily analyzed using CE, these compounds are difficult to identify directly using other analytical techniques, such as gas chromatography

(GC), in which chemical derivitization would be required.

Currently the primary limitation to the widespread use of CE for trace analysis is the lack of suitable low-sample volume (nanoliter-picoliter) optical detectors. Consequently, the high separation resolution delivered by CE is often lost at the detection stage. The most sensitive optical techniques currently in use are based on laser induced fluorescence and are limited to fluorescent molecules or molecules that can be easily derivitized with the appropriate fluorophore. This limitation often precludes the use of CE for rapid ultrasensitive field deployable sensors. Notably, laser induced fluorescence cannot be directly applied, in general, to trace analysis of actinides in aqueous solution due to their low fluorescence quantum yields. In addition, radionuclide counting techniques are limited in this application due to the dependence of the detection limit on the observation time and radionuclide lifetime. In capillary electrophoresis, typical peak widths are only several seconds wide and so only a several second observation time is possible without limiting separation efficiency or increasing the total analysis time. Scintillation detectors consequently are not easily optimized for both maximum analysis speed and sensitivity.

Work on universal CE detectors (i.e. detectors that respond to virtually all compounds) is currently a major topic of research. Under Advanced Concepts research in FY94-95, we explored the fundamental measurement physics, feasibility and general performance issues involved in the design of a novel all solid state ultra-sensitive universal CE detector. As illustrated in Figure 2., the device is based on two beam interferometry in a compact fiber coupled integrated optic Mach-Zehnder interferometer (MZI). One arm of the interferometer includes a small section of the CE capillary. Detection of the electrophoretically separated analyte is accomplished by monitoring the optical phase shift that results from refractive index changes in the CE capillary as different chemical species pass through the MZI sample arm. A substantial increase in sensitivity is obtained by including an amplitude modulated excitation beam to generate photo-induced refractive index changes via analyte absorption. Phase modulation resulting from the absorption process is detected by optical heterodyning with the MZI reference arm. Excitation

wavelengths can be chosen to enhance the selectivity of specific analytes or to provide a universal detection capability. Most aqueous solutes have strong broadband absorptions in

the UV spectral region.

The key feature that separates this approach from other thermo-optical and interferometric-based CE detection approaches is the use of close coupled CE/IO device architectures and all solid state laser technology. This approach has a number of attractive features. Optical phase information is demodulated, by detection of all the light emerging from the interferometer rather than a spatially selected component or fringe. Consequently, the signal is independent of thermal lensing artifacts due to the spatial distribution of the excitation beam and is also much less sensitive to misalignment than conventional fringe shift techniques. Unlike, photothermal lens (PL) and photothermal deflection (PD) based detection systems, the signal level is not dependent on the distance between the sample and the photodetector. PD and PL techniques typically require sample to detector distances on the order of 1.5m - 0.15m for maximum sensitivity, the integrated optic capillary electrophoresis (IOCE) system, however, is inherently compact with no large optical lever arms and subsequent mechanical stability requirements.

The system is also well suited to both active or passive homodyne stabilization techniques that would be necessary for actual field deployment, as well as programmable multiple modulation based detection schemes for removal of background absorptions. Other potential advantages include, wide dynamic range, high sensitivity, and low overall energy budget. Results from our FY94-95 Advanced Concepts effort have established the general feasibility of this approach by: (1) demonstrating our ability to efficiently couple high quality optical beams between buffer filled CE capillaries and waveguide structures, (2) developing an actively stabilized discrete component IOCE system protoype, and (3) demonstrating detection of photo-induced absorption signals in 20 micron water filled

fused silica capillaries at detection levels on the order of 2X10-7 absorbance units.

In the last few years, advances in CE miniaturization have resulted in the development of entire CE systems including electrokinetic sample injectors on palm sized glass "chips".2,3 This type of planarized chip technology is ideal for interfacing with IOCE detection systems described above. As a result of the Joule heating accompanying electrophoresis, thermal management is a crucial parameter in determining both efficiency and resolution in CE separations. To address this issue, we have developed and tested a micro-fabrication strategy for electrokinetically injected planarized CE systems on advanced high thermal conductivity, nonconductive ceramic substrates. (see Figures 3 and 4.) Although these devices are more difficult to fabricate than the conventional glass packages they promise substantially higher performance. Average size of some of the prototype devices allows them to be placed on top of a US quarter.

Choice of CE chip substrate material used in microfabrication provides a yet untapped parameter for CE system optimization. Thermal conductivity of the CE chip substrate can easily be increased one to two orders of magnitude over conventional fused silica and glass based systems. For an IOCE-type detector system this should translate to increased system response time and decreased analysis time. New CE chip substrate materials also permit optimization of crucial solute/capillary wall interactions via choice of inherent substrate surface charge states. The final phase of our IOCE Advanced Concepts work for FY96 will further develop and characterize the IOCE detection technology and integrate it with the ceramic planar chip CE devices into a full phase II prototype sensor. This phase II prototype will provide the relevant design criteria and engineering tolerances

for the sensor module proposed here.

Initial collaborations will be concerned with optimizing the planar Collaborators: chip CE system performance, automated sample preparation and dual use applications. Possible collaborators include CE researchers, Dr. Richard Chadwick (Analytical Chemistry R&D Division, Alergan Optical), Professor Warner Kuhr (UC Riverside), Dr T.R. Wang (Applied Research and Advanced Development Division, Beckman Instruments). As the IOCE technology reaches maturity and is ready for final testing, collaborations with researchers at LLNL and other DOE laboratories that have been involved in identifying proliferation signatures found in aqueous effluents and/or developing chemical analysis protocols for these signatures based on CE is anticipated.

Work for others: None

Proposed Work and Scientific Basis:

We propose the final design, fabrication and testing of a complete chemical microsensor module including automated micro-sample injection and prefiltering systems. The sensor system will be based on planar chip capillary electrophoresis, integrated optical detection technology and micro-electro-mechanical sample processing. Using the physical insights and engineering data obtained from our FY94-96 IOCE Advanced Concepts studies, an optimized IOCE sensor module will be developed. Previous Advanced Concepts Phase I and Phase II IOCE sensor prototypes have been designed around commercially available laser and IO components without regard for the minimum obtainable package size or overall system energy efficiency, since the intent of that work was initial demonstration of laboratory feasibility and engineering development. The work proposed here will determine the limits of microfabrication technology and packaging for this type of device and address packaging concerns pertinent to higher levels of subsystem integration. The project will proceed in three phases, (I) baseline, risk reduction, testing and development of enabling microtechnologies, (II) initial sub-system integration and testing, and (III) final microsensor module fabrication and performance demonstrations.

The FY97 effort will be composed of four parallel efforts: high performance substrate planar chip CE design, optimization and testing, fiber coupled UV microchip laser source development, monolithic (single substrate) integrated MZI/laser/ photodetector IO chip fabrication, and prototyping of a microvalve sampling and injection manifold. FY98-99 will comprise final subsystem integration, system electronics packaging and performance testing of the completed chemical microsensor module under simulated field conditions. IOCE microsensor technology makes simultaneous operation of multiple sensor modules either discretely packaged and interfaced or fabricated on a single chip feasible. Advantages and potential applications of this type of multiplexed sensor operation other than simple system redundancy will also be evaluated.

Integrated optical components of the type required for the sensor module and used in our Advanced Concepts prototypes were based on lithium niobate waveguide technology. This IO technology is well established as reliable, rugged and field proven both in military and industrial applications. Hybrid microintegration of laser diodes and photodetectors with these components has been reported and is a viable option for use in the proposed sensor. A,5 The technology for lithium niobate IO fabrication and packaging is well established at LLNL. Use of lithium niobate for the waveguide material, however, precludes the possibility of monolithic integration of the semiconductor laser diode source and semiconductor photodetectors onto a single common substrate. Monolithic component integration can have tremendous benefits for the proposed sensor in terms of absolute package size, reduced coupling losses, enhanced stability and mass production.

We propose to fabricate a fully monolithic integrated sensor detection system on a common GaAs substrate using AlGaAs/GaAs epitaxial growth technology. 6,7 (See Figure 5.) The Mach-Zehnder functionality will be achieved through the use of semiconductor optical amplifiers (SOAs) as optical phase shift elements and amplitude controllers. 8 The ability to utilize the same semiconductor layers for different functionality

dramatically simplifies the fabrication of the laser/MZI/detector chip. Dozens of devices may be simultaneously fabricated in a single production sequence on a 50 or 65mm wafer.

To produce the chip, a laser diode section is defined by forward biasing a (single-mode) waveguide section with parallel optical facets, an SOA is fabricated similarly but with low reflectivity facet interfaces and the photodetector is an unbiased or reverse biased waveguide absorber which generates a photocurrent. The waveguide sections are regrown after etching (photolithographically defined) with transparent, low loss material deposition. Two key fabrication technologies are essential to constructing the SOA MZI chip: chemical etching for definition of laser facets and the low-loss waveguide deposition process for the AlGaAs/GaAs material system. Final package size of a chip based on this technology would be on the order of 1mm x 5mm. We believe that LLNL is uniquely positioned to prototype the MZI sensor chip because the LLNL passive waveguide process on ALGaAs/GaAs is unique in the world and our etching technology is the state of the art. (see figures 6 and 7).

Recent breakthroughs in semiconductor diode laser technology, high efficiency diode laser fiber coupling (90%) and quasi-phasematched frequency conversion technologies make fabrication of a highly efficient, versatile all solid state UV microchip laser excitation source for the proposed IOCE module feasible. Microchip lasers are miniature, high performance solid state diode pumped lasers fabricated from 1-3mm³ solid state laser "chips". (See Figure 8.) The laser resonator is formed by depositing cavity mirrors directly on the chip faces to form a monolithic cavity. The performance characteristics of these devices result from their inherently short cavity length and pump source induced thermal lensing properties that produce an auto-stabilized condition for efficient single transverse mode (TEM00) operation in conjunction with the marginally flat /flat solid state optical resonator structure. Some of their characteristics include simple single frequency operation, tunability over the gain bandwidth without mode hopping, short pulse and high peak power capability and high speed frequency and amplitude modulation capability. Composite cavity lasers composed of laser "chips" and "chips" of nonlinear materials sandwiched together allow highly efficient frequency conversion of the solid state laser output. Optical design, fabrication and development of suitable fiber coupled UV microlaser system for the chemical sensor module will be undertaken. Initially, commercially available micro-chip laser modules operating at their fundamental or second harmonic will be used to evaluate this technology and determine the optimal nonlinear frequency mixing scheme for UV generation via sum frequency mixing or third harmonic generation.

Lastly, microfabrication techniques will be used to construct the necessary miniaturized valves and flow capillaries required for the sample collection, pre-analysis processing and injection manifold. Recent advances in the adaptation of microfabrication techniques originally developed for the microelectronics industry have been increasingly adapted to build mechanical devices in the growing field of Micro-Electro-Mechanical Systems (MEMS). Advances in MEMS technology are rapidly increasing the feasibility of integrated microflow systems and micro-instrumentation. The ability to integrate smart microelectronics for instrument control and data analysis along with mechanical and optical components required for a given analytical technique will permit the user to interface with the instrument at a much higher functional level than with present instruments, which are composed of many separate modules that must be interfaced and operated by the user. LLNL has advanced capabilities and experience necessary to develop the proposed components and is already developing a variety of chemical analysis microinstruments with

We propose to develop a miniaturized sample collection and precision injection system based on micro-valve technology for the capillary electrophoresis chemical analysis sensor module. LLNL and Redwood MicroSystems, Inc. (Menlo Park, CA) are presently working together to expand Redwood's FluistorTM product line of micro-fabricated valves.

(see Figures 9 and 10) The devices are micro-fabricated in silicon and are based on Redwood's thermopneumatic actuation principle. The microactuator is among the few which provides both high force and displacement needed for valve applications. The actuator motion is precise enough that it can effectively control flows over six orders of magnitude. Efforts are currently focused on new generations of valves which are faster, chemically resistant, normally-closed, and compatible with liquids. Work is also underway to integrate micro-valve arrays with microflow channels, pressure and flow sensors to form high performance, microflow systems for pressure regulation and flow control. We plan to exploit these technological developments in the proposed IOCE chemical sensor module. An important decision for the first prototype is to determine whether to actuate the microvalves with an integrated microfabricated actuator or an external actuator. The integrated microvalve actuator would have size advantages and be more faithful to the "microinstrument" concept, but the external actuator would initially have lower development costs, shorter development times, and possible performance advantages. Consequently, we will develop the first prototypes with external valve actuation in order to demonstrate system performance and then add integrated actuation as we approach final subsystem integration in FY98. Size of the completed microvalve manifold package will be on the order 50x50x3mm. Future generations could be reduced in size to 25x25x3mm.

The proposed microvalve work will leverage the results of ongoing microinstrumentation projects in the LLNL MicroTechnology Center (MTC) such as: (1) microvalve development in a CRADA partnership with Redwood MicroSystems, the world's leader in microfabricated valve technology; (2) development of high-throughput, high resolution capillary gel electrophoresis instruments for DNA sequencing; (3) portable gas chromatography chemical analysis systems; (4) microfabricated chemical reactors for the polymerase chain reaction (PCR); (5) miniature flow cytometers for cell sorting; (6) microchannel coolers for high power laser diode arrays; and (7) microfabrication of precision capillaries by etching and bonding of glass and silicon wafers.

Research and Development Issues:

- Issue 1. The planar chip CE technology must be optimized for field sensor applications. CE chip design parameters must be engineered to optimize separation performance and minimum size. The best choice of CE chip substrate material, capillary size, separation voltage, electrokinetic sample injection parameters, and the mechanical packaging of the buffer and sample reservoir feeds must be determined.
- Issue 2 An IOCE module package suitable for field deployment that minimizes microphonics and thermal management problems must be designed. A microoptic packaging strategy and optical design for interfacing the planar CE chip, the microchip laser excitation source and the integrated optic detection system waveguides must be developed.
- Issue 3 General feasibility of the monolithic single substrate SOA Mach-Zender interferometer concept must be demonstrated at a level of performance suitable for use in the IOCE sensor module. If this approach does not meet expectations, a microoptical packaging strategy for the lithium niobate waveguide devices will need to be developed and implemented.
- Issue 5 A compact energy efficient, reliable UV microlaser excitation system suitable for field operation must be designed and demonstrated. An efficient, low power, nonlinear optical frequency conversion scheme based on either third harmonic generation or sum frequency mixing of the micochip laser output must be designed and optimized and packaged.

- Issue 6. Design and engineering of an automatic sample collection and prefiltering system must be completed to accommodate true field samples
- Issue 7. Size reduction and packaging of support electronics and system power supply must be addressed
- Issue 8. The optimum detection format and operating parameters for field deployment must be determined for the IOCE module

During FY97 the following tasks will be performed:

- Task 1 Baseline CE and IO micro-package engineering, integration and testing (\$500K)
 - (1.0) detailed mechanical and optical system design
 - (1.1) microfabrication and evaluation of planar chip CE test components from high performance substrate materials
 - (1.2) thermo-mechanical characterization and integration of planar chip CE and discrete commercial lithium niobate IO components.
 - (1.3) preliminary characterization and demonstration of baseline system separation and detection capabilities using optimized CE chip substrates (1.4) development of IOCE test platfom for sub-system test and evaluation
- Task 2 Development and testing of compact, energy efficient, high beam quality UV microchip laser system and interface to IOCE sensor module (\$250K)
- Task 3 Evaluation and testing of the SOA MZI concept for sensor applications; build and test and characterize a hybrid SOA MZI using discrete components. (\$350K)
 - 3.1) Fiber pigtail and package existing LLNL laser diode and SOA chips with polarization maintaining fiber.
 - (3.2) Test individual components -- SOA gain and phase shift as a funtion of current, laser diode threshold and output power versus current, laser diode linewidth and laser diode susceptibility to optical feedback, polarization extinction ratios of fiber splitters.
 - (3.3) Configure LLNL laser diode, SOA, photodiode and fiber splitter components into the MZI configuration. Characterize contrast ratio, stability to temperature, vibration and optical feedback effects on MZI transmission. (3.4) Test and evaluate discrete component prototype developed in task 4.3 in IOCE sensor test system to compare with lithium niobate IO technology.
- Task 4 Preliminary design, development and testing of automated microvalve sampling and filtering system. (\$380K)
 - (4.1) Discrete valve development:

 Determine actuation mechanism and general approach
 Design discrete valve and package (2 iterations)
 Photomask layout (2 iterations)
 Microfabricate valve chip (2 iterations)
 Fabricate package (2 iterations)

Test discrete valves (2 iterations)

(4.2) Sample injection and processing manifold development:

Design injection manifold chip (2 iterations)

Design manifold package and interface (2 iterations)

Solve gas generation/bubble problem

Photomask layout (2 iterations)

Microfabricate manifold chip (2 iterations)

Fabricate packages and interfaces (2 iterations)

Test manifolds (2 iterations)

(4.3) Discrete copmonent integration and testing with IOCE system

FY97 CAPITAL \$ JUSTIFICATION

commercial laser systems for prototype development and testing		30K
(customized diode laser and microchip laser systems)		55K
subsystem IO components micro-manipulation equipment	•	20K
support electronics and electronic test equipment		<u>45K</u>
support ofcottoning and office an	Total:	\$150K

FY97 SCHEDULED MILESTONES

NUMBER DUE DATE COMPLETION DATE

1 01 / 15 / 97 Initial optical and mechanical design work complete. Specification and procurement of critical system components and fabrication contracts complete. Fiber pigtail packaging and fabrication of SOA test chips complete. Preliminary design discrete microvalve system complete

2. 06 / 1/97

Fabrication and testing of CE hardware test chips and fixtures incorporating initial design ideas complete. Preliminary evaluation of microchip laser technology and preliminary frequency conversion experiments completed. Individual SOA component testing is complete. Microvalve manifold design is complete.

3. 08 / 01 / 97
Phase I IOCE sensor test bed is assembled and performance characterized with commercial lithium niobate IO technology. LLNL SOA/MZI components are assembled and characterized. Feasibility of the SOA/MZI concept is determined. Microvalve manifolds are assembled and tested.

4. 10/01/96

Demonstration of test module incorporating all critical design components.

FY97 SCHEDULED DELIVERABLES:

NUMBER	DUE DATE	COMPLETION DATE
1 LLNL sends DOE/HQ	01 / 20 / 97 Quarterly Report for Octo	ber through December 1996
2 LLNL sends DOE/HQ	04 / 20 / 97 Quarterly Report for Janu	eary through March 1997
3. LLNL sends DOE/HQ	07 / 20 / 97 Quarterly Report for Apr	il through June 1997
4. LLNL sends DOE/HQ	10 / 20 / 97 Quarterly Report for July	through September 1997
5. LLNL sends DOE/HQ IOCE sensor module	10/20/97 Preport on design and page	ckage engineering test data for

During FY98 the following tasks will be performed:

- Develop a monolithic, chip SOA MZI chemical sensor using active/passive Task 1. waveguide integration technology. Test and deliver several prototype chips. (\$650K)
 - 2.1) Fabricate laser diode, SOA and photodiode sections using CAIBE etching of a single substrate. Test individual component performance.

2.2) Fabricate passive wavegiude sections and measure loss, split ratio and

extinction ratio.

- 2.3) Fabricate 3 dB couplers using LLNL passive waveguide technology and characterize. Integrate a single passive waveguide section with active laser diode and/or SOA.
- 2.4) Fabricte monolithic SOA MZI chip. Connect to CE chip using fiber. Test performance.
- Implementation of final IOCE sensor module design. Optimize source laser Task 2. design. Complete system engineering tests and mechanical design characterization of final sensor module. Integrate all sub-components into final package (\$850K)
- Size reduction and packaging of support electronics and system power Task 3. supply (\$300K)

FY98 CAPITAL \$ JUSTIFICATION

Final laser technology, IO components and custom compact low energy budget data collection and signal processing electronics (\$50K)

FY98 SCHEDULED MILESTONES

	<u>NUM</u>	<u>BER</u>	DUE DATE	COMPLETION DATE
	1 Comple	ete final syster	01 / 15 / 97 n design and design modif	ications.
	2. Fabrica	ation and testin	05 / 10 / 97 g of prototype module inco	orporating design changes complete.
	3. Assem	bly and testing	06 / 01 / 97 of final hardware.	
	4. Testing specific	g of sensor mocations determ	07 / 01 /97 dule under simulated field o ined.	conditions complete. Operating
	5. Demor	nstrations of se	10 / 01 / 97 elected systems for trace an	alysis complete
FY98	SCHE	DULED DE	LIVERABLES:	
NUM	BER	DUE	DATE C	OMPLETION DATE
	1 LLNL	sends DOE/H	01 / 20 / 98 Q Quarterly Report for Oct	ober through December 1997
	2 LLNL	sends DOE/H	04 / 20 / 98 Q Quarterly Report for Jan	uary through March 1998
	3. LLNL	sends DOE/H	07 / 20 / 98 Q Quarterly Report for Apr	il through June 1998
	4. LLNL	sends DOE/H	10 / 20 / 98 Q Quarterly Report for July	through September 1998
	5. LLNL	send DOE/HÇ	10/20/98 report on IOCE micro se	nsor module integration and testing
During FY99 the following tasks will be performed:				
Task	1.	Develop seco	nd generation SOA MZI p	ackage. Make prototypes. (\$350K)
Task	2.	Final modific integration of	ations and optimization of custom control microelect	IOCE sensor module package and ronics (\$600K)
Task	3.	Simulated fie analysis demo	ld testing of completed choonstrations. (\$250K)	emical sensor module and trace

FY99 CAPITAL \$ JUSTIFICATION

Final laser technology, IO components and custom compact low energy budget data collection and signal processing electronics (\$50K)

FY99 SCHEDULED MILESTONES

<u>NUMBER</u>	DUE DATE	COMPLETION DATE
1. Task 1 complete	06/01/99	
2. Task 2 is completed.	08 / 01 /96	
3.	10 / 01 / 96	

Demonstrations and system characerization is complete.

FY99 SCHEDULED DELIVERABLES:

NUMI	BER DI	UE DATE	COMPLETION DATE
	1 LLNL sends DOE	01 / 20 / 98 E/HQ Quarterly Report	for October through December 1998
	2 LLNL sends DOF	04 / 20 / 99 E/HQ Quarterly Report	for January through March 1999
	3. LLNL sends DOF	07 / 20 / 99 E/HQ Quarterly Report	for April through June 1999
	4. LLNL sends DOI	10 / 20 / 99 E/HQ Quarterly Report	for July through September 1999
	5. LLNL send DOE, performance chara	10/20/99 'HQ report on final IO acteristics and simulate	CE micro sensor module design, d field test results

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2. C.S. Efffenhauser, A. Manz, and H.M. Widmer, "Glass Chips for High Speed Capillary Electrophoresis Separations with Submicrometer Plate Heights", Anal. Chem. 65, 2637-2842 (1993).

3. A. Manz. E. Verpoorte, C.S. Effenhauser, N. Burggraf, D.E. Raymond and H.M. Widmer, "Planar Chip Technology for Capillary Electrophoresis", Fresenius J. Anal. Chem. 384, 567-571 (1994)

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 Y. Yamada, A. Sugita, K. Moriwaki, I. Ogawa, and T. Hashimoto, "An Application of Silica-on Terraced-Silicon Platform to Hybrid Mach-Zehnder Interferometric Circuits Consisting of Silica-Waveguides and LiNbO3 Phase-Shifters", IEEE Photon. Tech Let., 6, 822-825 (1994)

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7. Tanbun-Ek, P.F. Sciortino, A.M. Sergent, K.W. Wecht, P. Wisk, Y.K. Chen, C.G. Bethea, and S.K. Sputz, "DFB Lasers INtegrated with Mach-Zehnder Optical Modulator Fabricated by Selective Area Growth MOVPE Technique", IEEE Photon. Tech Let., 7, 1019-1021, (1995).

8. T.Durhuss, C. Joergensen, B. Mikkelson, K.E Stubkjaer, "Monolithic Integrated Mach-Zehnder Wavelength Converter: Conversion and Transmision Experiments at

5 Gbits/s", OFC '95 Technical Digest, TuO6, p 75-76, (1995)



Figure 1. The microliter water sample shown above is one thousand times larger than the typical sample volume required for chemical analysis by capillary electrophoresis (CE).

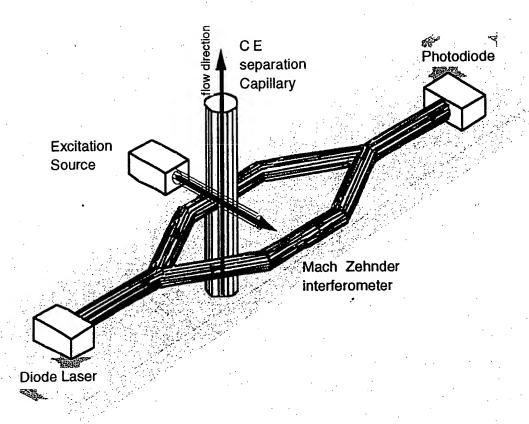


Figure 2. Conceptual diagram of the integrated optic capillary electrophoresis (IOCE) sensor module. Sample analytes are separated in the CE capillary by electrophoresis based on thier charge to mass ratio and detected by two beam interferometry. Use of a modulated excitation source increases the detection sensitivity by allowing photoinduced refractive index changes due to analyte absorption to be measured with a high signal to noise ratio.

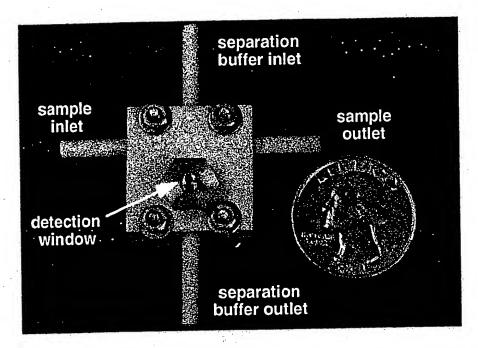


Figure 3: Ceramic planar chip CE system fabricated at LLNL for test and evaluation as part of our FY95 Advanced Concepts effort.

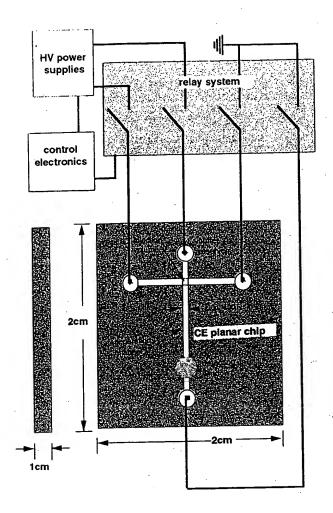


Figure 4: Schematic of capillary system micro-machined in the ceramic chip shown above. Samples are electro-kinetically injected into the separation capillary by applying a low voltage for a short period across the sample capillary. The sample is then electrophoretically separated by switching the voltage across the separation capillary.

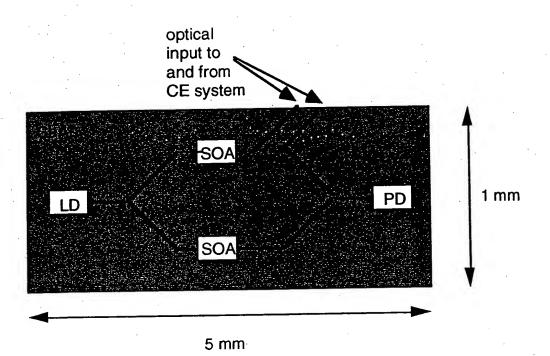


Figure 5. Schematic (not to scale) of a fully integrated Mach-Zehnder sensor using a semiconductor laser diode (LD) as the optical source, semiconductor optical amplifiers (SOAs) as optical phase shift/gain elements, passive single-mode waveguides to form the interferometer section and a semiconductor photodiode (PD). This photonic circuit can be constructed using several existing LLNL proprietary fabrication technologies.

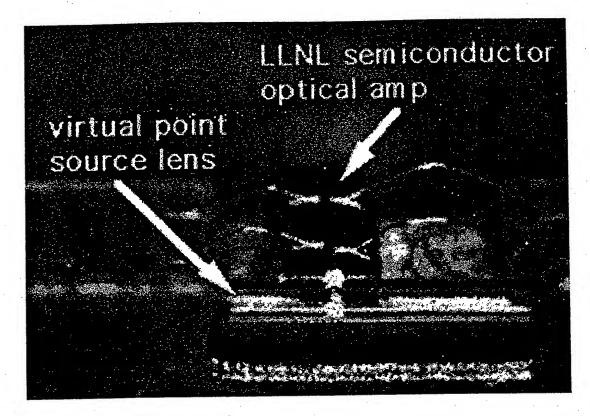


Figure 6. Example of semiconductor optical amplifiers (SOA's) fabricated and packaged at LLNL. We plan to leverage this technology in the proposed work.

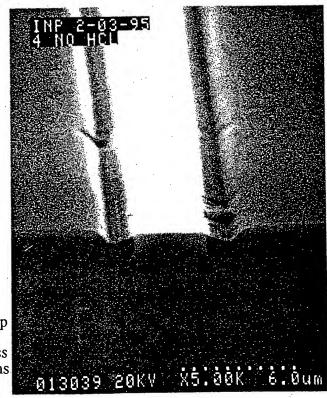


Figure 7. Scanning electron micrograph (SEM) showing the deposition of a thick oxide layer on top of an InP-based ridge SOA. In FY96 we will employ this deposition process to integrate passive waveguide sections with active SOAs.

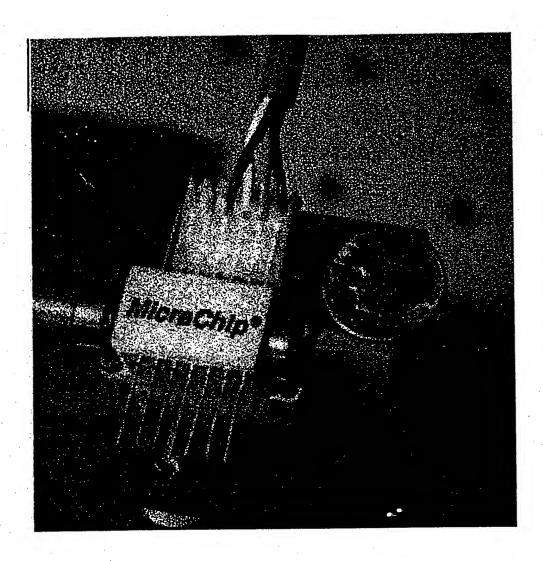


Figure 8. We plan to develop a UV excitation source suitable for the proposed IOCE sensor module based on an extention of diode pumped solid state microchip laser technology. An example of a frequency doubled commercial microchip laser is shown in the figure.

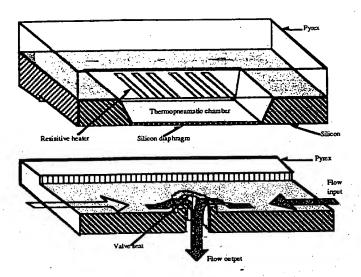


Figure 9. An exploded cross section of the thermopneumatically actuated microvalve. Heating the fluid within the chamber causes expansion, which bulges the diaphragm onto the valve seat, thereby closing the valve.

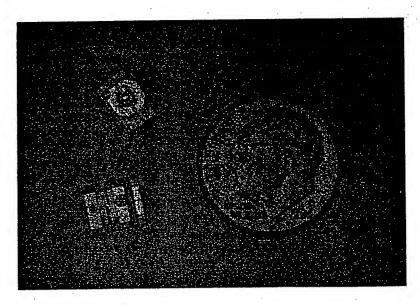


Figure 10. Redwood MicroSystems' microfabricated valve (Fluistor TM). The valve measures 6x6x2mm.

•	Patent Priority List - Scoresheet	High 20 Date: June 1999
. #: 9928	Directorate: NAI	Inventors: Anthony J. Ruggiero
tle: Integrated Opt	tle: Integrated Optical Capillary Electrophoresis Chemical Microsensor	Non-LLNL Inventors:
Check all that apply)	t apply) High 20 Priority:	Additional comments (Specialist/Program Rep)
XX Rec	ded 1	Three companies interested in this technology. Close to a reduction to practice. This is the program's top-ranked case for patenting
Im Im	Important technical invention	
XX	Commercial value	
XXX Sign	Significant Programmatic interest	
	Important LLNL portfolio (e.g. Aerogels)	
X	Proof of concept exists	
CRA	CRADA BIP	
CRA	CRADA Subject Invention	
Liœ	License executed	
Ë	License in negotiation	
XXX Com	Commercial interactions/marketing	Selected by IPAC for Top 20 (Weis/Dunipace) 6/23/99 (3)
₩	Other time factors (bar date, provisional)	Added to Top 20 List July 7, 1999
Bar Dates: ☐		Search Completed Portfolio

Business Specialist: Annemarie Meike

Publication Date:

1 Provisional filing date:

ATTACHMENT C

NEW IL'S REPORT NOVEMBER 2003

IL Number

•6/4/96: TL-Check on sponsor's attitude towards licensing this Daubenspeck if rights haven't technology and get back to Review Action Items •5/4/99: BW-Check with •6/1/99: Waive & File VL-Waive and file Waive and File been granted. Veronica. RM-It's patentable. A publication went out 320/96 to DOD for a conference. Think it's a wonderful disclosure–solid and well thought out. We need to take some action soon because of a possible bar date. VL-Evidentally, DOE never did grant them. Mixup with paperwork. Resent paperwork and they will *6/4/96: TS-Would like to go forward with this one. NN-20 is not currently 5/4/99: AD-There are three companies interested in granted. Linda Lemer will send 2nd request to DOE. this. Think the sponsor wants to commercialize. No •5/4/99: kb-Rights requested 7/23/96, though never 6/1/99: BW-Checked with Daubenspeck and espond back. By the time we get ready to do op 20, we should hear from DOE. Linda can AD-Full prototype is to be complete within one /L-NN-20 is the sponsor. We need to find out how they feel about us publications. Real close to reduction to practice. **Review Comments** haven't heard back. give us an update. BW-We ought to write it. Priority # Filing Date **Priority List** Provisional 6/8/2001 Revisits June99 66/1/1 June Capillary Electrophoresis Chemical Microsensor Anthony J. Ruggiero Rights Requested Inventor/Title Integrated Optical Rights Granted 5/25/1999 9/7/2000 9928 Program Ted Scharlemann (sub for O Requires Review Revisit O Requires Review Abeyance Lanier, West, Weis Annemarie Meike Patents Richard Main O Priority 1 O Refer to DOE Waive & File O Inactivate O No Interest Arden) O Waive P&C BDE Account Nos. Directorate No Interest by 5382-50 June 96 Month

BUSINESS SENSITIVE, I HEAT AS PROPRIETARY INFORMATION Top 20 Candidates

ATTACHMENT D

4/9/1996

Provi

Disclosure Submitted 4/9/1996 Annemarie Meike Specialist Inventorspecialist Name Anthony J. Ruggiero Integrated Optical Capillary Electrophoresis Chemical Microsensor Title Directorate Ä Priority #

LLNL Patent Group - Patent Tracking

ATTACHMENT E

•		Man Lab				
IL- 9928	IL Type	Non-Lab Inventor	Cont. App.	Assign	ee UC/IP&C	
AIPA Applies	R	L- 13,534	S- 85,91	5 ι	IC-	
Attorney	<u> </u>		Date Attorney		00	
ROI Tit	i	Capillary Electropho	oresis Chemical Mic			
F	ny J. Ruggiero First Office Actionresp On Patent Priority List (o. due 1/8/2003 (kr).	Application mailed	Non-LLNL Invento		oy IP&C. Put
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Serial No. Additional Pr	ovisional	Filing Date	neck priority date	Priority Export Contr		
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Serial No.	09/877961	Filing Date 6/8	/2001	Bar Date 2		
Patent No.		Issue Date ch	eck priority date	Bar Date 3		
Publication Cite		Publication Date	ook phonly date	EUVL Assignee		
Portfolio						
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First Office Action	10/8/2003	First OA	Sent	
Second Office Action		Second OA	Sent	-
Third Office Action		Third OA	Sent	
Fourth Office Action		Fourth OA	Sent	
Final Office Action		Final OA	Sent	
Notice of Appeal Due	·	Notice of Appeal		
Appeal Brief Due		(Check Response D Appeal Brief		
CPA Filed	7 .	RCE filed		
1st CPA OA	1st CPA OA Sent	1st RCE OA		1st RCE OA Sent
2ndCPA OA	2nd CPA OA Sent	2nd RCE O	A .	2nd RCE OA Sent
Final CPA OA	Final CPA OA Sent	Final RCE C	DA .	Final RCE OA Sent
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Response Due		e Due Dates		
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Fee Due Seven Yr	Three Yr Fee Paid Seven Yr	TENANCE FEES	Three Year	Number 9928
Fee Due Seven Yr Fee Due	Three Yr Fee Paid Seven Yr Fee Paid	TENANCE FEES	Three Year Amount	Number 9928
Fee Due Seven Yr Fee Due Eleven Yr	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr	TENANCE FEES	Three Year Amount Seven Year Amount Eleven Year	Number 9928
Fee Due Seven Yr Fee Due	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid	TENANCE FEES	Three Year Amount Seven Year Amount	Number 9928
Fee Due Seven Yr Fee Due Eleven Yr Fee Due	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid	TENANCE FEES C INFORMATION	Three Year Amount Seven Year Amount Eleven Year	Number 9928
Fee Due Seven Yr Fee Due Eleven Yr Fee Due Small Entity Yes [Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid No IP&	C INFORMATION	Three Year Amount Seven Year Amount Eleven Year Amount	
Fee Due Seven Yr Fee Due Eleven Yr Fee Due Small Entity Yes Licensee ATL-00: 7/12/02	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid No IP& 32-02, BAE Systems, Option Agreement	C INFORMATION Licensing	Three Year Amount Seven Year Amount Eleven Year	
Fee Due Seven Yr Fee Due Eleven Yr Fee Due Small Entity Yes Licensee ATL-00: 7/12/02	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid No IP& 32-02, BAE Systems, Option Agreement 3-02, BAE Systems, 9/19/02	C INFORMATION Licensing Specialist	Three Year Amount Seven Year Amount Eleven Year Amount	
Fee Due Seven Yr Fee Due Eleven Yr Fee Due Small Entity Yes Licensee ATL-003 7/12/02 TL-1738	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid No IP& 32-02, BAE Systems, Option Agreement 3-02, BAE Systems, 9/19/02	C INFORMATION Licensing	Three Year Amount Seven Year Amount Eleven Year Amount	
Fee Due Seven Yr Fee Due Eleven Yr Fee Due Small Entity Yes Licensee ATL-003 7/12/02 TL-1738	Three Yr Fee Paid Seven Yr Fee Paid Eleven Yr Fee Paid No IP& 32-02, BAE Systems, Option Agreement 3-02, BAE Systems, 9/19/02	C INFORMATION Licensing Specialist Date Assigned	Three Year Amount Seven Year Amount Eleven Year Amount	
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Account Nos.	5382-50		Aime		
Additional Provisional Seria	a No. Filing Date				
Agents File Nos.					
Appeal Brief Due					
Appeal Brief Sent					
Applicant	Regents of the University of California				
Application Authorized	<u>5/25/1999</u>				
Application Mailed	6/8/2001				
Application Requester	IP&C				
Assignee	<u>UC/IP&C</u>				
Attorney	Scott				
Attorney Foreign	Scott				
Attorney Comments					
BandR No.	GC0101093				
Case Combined with					
Confirmatory License	<u>8/27/2001</u>			,	
Cont. App.					
Countries	All PCT National filing in and Ja	pan			<u> </u>
Date Att. Assign.	6/1/2000				-
Directorate Priority	1				
Disclosure Submitted	<u>4/9/1996</u>				
Eleven Year Amount					
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Filing Date	6/8/2001				
Final OA Sent					
Final Office Action					
First OA Sent					
First Office Action	10/8/2003				
For. Response Due					
Foreign Agents					
Foreign Status	12/1/2003: L&P confirmed filing in EPO and JP(ns)]			
Foreign Title	Chemical Micro-Sensor	Ī			
Fourth OA Sent		Ī			
Fourth Office Action		-			
IDS Due	9/6/2001		•	•	
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IL Index Key	9928	ĺ			
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Inactivated by DOE	
Inactivated by IPAC	
International Filing Date	5/31/2002
International Serial No.	PCT/US02/17125
Inventors	Anthony J. Ruggiero
IPAC PCT Req.	
Last Modified Date	12/17/2003
Last Person To Modify	Kathy Raymond
Last Modified Time	8:02:16 AM
Licensee	ATL-0032-02, BAE Systems, 7/12/02, Option Agreement
Miscellaneous Information	
Natl Appl. Nos.	
Notice of Allowability	
Notice of Allowability Sent	
Notice of Allowance Date	
Notice of Allowance Sent	
Notice of Appeal Due	
Notice of Appeal Sent	
Patent App. Title	Chemical Micro-Sensor
Patent Issued Date	
Patent Number	
Patent Status	First Office Actionresp. due 1/8/2003 (kr). Application
PCT Due	6/8/2002
PCT I National Entry	<u>2/5/2003</u>
PCT II Demand Due	1/5/2003
PCT II Demand Filed	7/23/2002
PCT II National Entry	12/6/2003
Priority Date	<u>6/8/2001</u>
Provisional Filing Date	
Provisional PCT Due	·
Provisional Serial No.	
Publication Cite	
Publication Date	
Related Cases	
Response Due	1/8/2004
Restriction Req. Sent	
Restriction Requirement	
Rights Granted Date	9/7/2000
Rights Requested Date	<u>5/25/1999</u>
RL Number	13,534

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Y ROI Title	Integrated Optical Capillary Electrophoresis Chemical				
S Number	<u>85,915</u>	_	·		
Second OA Sent					
Second Office Action					
Serial Number	09/877961	7			
Seven Year Amount		_			
Seven Yr Fee Due				•	
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Third OA Sent		_			
Third Office Action					
Three Year Amount					
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Three Yr Fee Paid]			
Type Requested	Identified Class Waiver W(C) 96-004				
UC number		j			
Patent Expiration Date		j			
Foreign Patent No.					Π
Foreign Issue Date					Ī
Prov. PCT Due Date					-
Non-Lab Employee					
Modification Index	2003351.08021				
No Interest by IPAC]			
High 20 Nominated Candid	a <u>66/23/99 (3)</u>]			
High 20's List	<u>7/7/1999</u>			,	
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Priority]			
Bar Date 1					
Foreign Bar Date					
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Bar Date 3					
Bar Date Comments]			
Portfolio]			
Abstract]			
	3/13/2003				
Written Opinion	·				
Response Sent					
Small Entity]			
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Second CPA Office Action									
Final CPA Office Action									
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Search Report Resp Sent							•		
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IPEA									
Request to Outside Counsel									
Supp Int'l Search Rpt Rec'd			-						
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Int'l Pre Exam Resp	·								
Written Opinion Resp									
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PCT Pub Date				.,					<u> </u>
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AIPA Applies								•	
Non LLNL Inventors									
Multiple Due Dates								•	
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RCE filed									
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First RCE Office Sent									
Second RCE Office Action									
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Final RCE Office Action									
Final RCE Office Sent									
Patent Application							•		
U.S. Patent									

Records of Invention

Business Sensitive, Treat As Proprietary Information

ATTACHMENT G

IL- 9928 IL Type	RL- 13,534 S- 8	5,915 UC-
Title Integrated Optical Capillary	Electrophoresis Chemica	al Microsensor
Status First Office Actionresp. due 1/8 by IP&C. Put On Patent Priority	/2003 (kr). Application mailed (List On 7/7/99.	6/8/2001. Application authorization
Anthony J. Ruggiero		
Disclosure Submitted 4/9/1996	Application Date	on Authorized 5/25/1999
Publication Number		Portfolio
ı	Bar Date 1 Serial Number	Filing Date
Patent		5/8/2001
Provisional		
Attorney Scott	Paten	t Issued Date
Directorate NAI H	igh 20's List	Dir. Priority 1
7/7		nsing cialist Annemarie Meike
Related Cases		Statist ———————————————————————————————————
Last Person To Modify Kathy Raymor	nd 12/17/2003	8:02:16 AM
Miscellaneous Information		
Modification Index 2003351.0	080216	
Review Comments		Review Action Items
*e3/4/98: TS-Would like to go forward with this one. NN-20 is not currently VL-NN-20 is the sponsor. We need to find out how they feel about us lices RM-It's patentable. A publication went out 3/2/99 to DOD for a conference disclosure-solid and well thought out. We need to take some action soon BW-We ought to write it. *5/4/99: AD-There are three companies interested in to commercialize. No publications. Real close to reduce 5/4/99: kb-Rights requested 7/23/96, though never go send 2nd request to DOE. *6/1/99: BW-Checked with Daubenspeck and haven't heard back. VL-Evidentally, DOE never did grant them. Mixulus paperwork and they will respond back. By the tir 20, we should hear from DOE. Linda can give us AD-Full prototype is to be complete within one year.	nsing this technology. e. Think it's a wonderful because of a possible bar date. this. Think the sponsor wants action to practice. ranted. Linda Lerner will p with paperwork. Resent ne we get ready to do Top is an update.	•6/4/96: TL-Check on sponsor's attitude towards licensing this technology and get back to Veronica. VL-Waive and file •5/4/99: BW-Check with Daubenspeck if rights haven't been granted. •6/1/99: Waive & File

Records of Invention

Business Sensitive, Treat As Proprietary Information

Abstract

OFFICIAL USE ONLY ATTACHMENT H DISCLOSURES, PATENT APPLICATIONS AUTHORIZED AND FILED 1/1/94 to 6/26/96

Directorate/	Account No.	IL#	Title	Inventor	Assignee	Specialist	Disclosure Submitted	Application Authorized
	5382-50	9928	Integrated Optical Capillary Electrophoresis Chemical Microsensor	Anthony J. Ruggiero	UC/IP&C		4/9/1996	5/25/1999

^{*}Disclosures assigned to DOE unless assignment requested by LLNL.

^{**}UC/OTT Alameda is the Technology Transfer Office for The Regents

		DIRECTORATE NOMINEE LIST September 2003	ELIST			o di terita	Provisional	
#	Title	Inventors	Priority	Priority Authorized	Bar Dates Date	Date	Filing Date	
9928	Integrated Optical Capillary Electrophoresis Chemical Microsensor	Anthony J. Ruggiero		5/25/1999				
			Pateni	Patent Priority List				
			1111	7/7/1999				

Directorate: NAI

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	Patent Pa	
	Patent Filing Date	6/8/2001
	Disclosure Date	4/9/1996
NIF ROI's Filed 7/1/02-6/30/03	Inventors	pillary Electrophoresis Chemical Anthony J. Ruggiero
	Account Nos. IL Type Title	Integrated Optical Capillary Electropho Microsensor
	Account Nos.	5382-50
	 	9928

	Added to List	7/7/1999
Cases Currently on the High 20	Inventors	Anthony J. Ruggiero
Cases Current	Title	Integrated Optical Capillary Electrophoresis Chemical Microsensor
		80



University of California LAWRENCE LIVERMORE NATIONAL LABORATORY Office of Patent Counsel

April/9, 1996

Mr. William C. Daubenspeck Office of Patent Counsel U.S. Department of Energy Livermore, California 94550

SUBJECT:

Invention Case No.: IL-9928

"Integrated Optical Capillary Electrophoresis Chemical

Microsensor"

By: Anthony J. Ruggiero

Dear Mr. Daubenspeck:

Enclosed is the original and one copy of the combined Disclosure and Record of Invention in the subject case.

Very truly yours,

Terry Contreras

Patent Group

Enclosure

cc: Howard B. Scheckman w/enc.

Jan Wallace w/enc.

Anthony J. Ruggiero L183 w/enc.